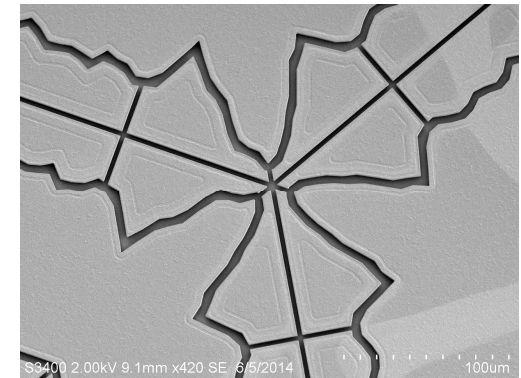
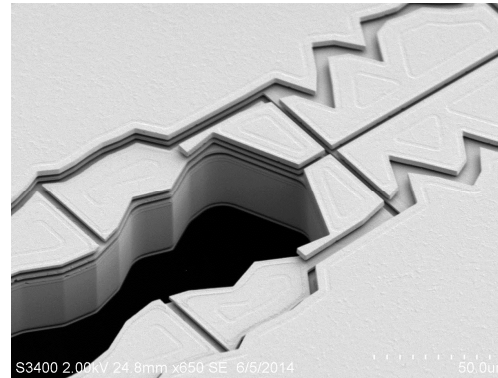
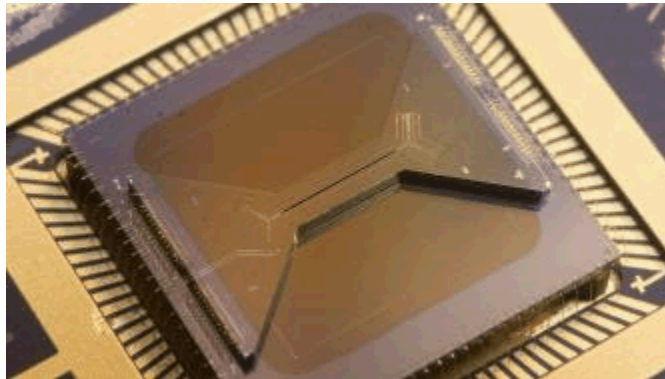
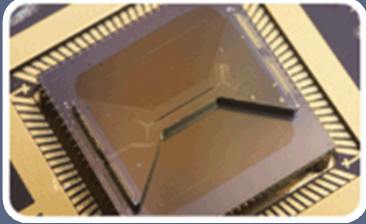


*Exceptional service in the national interest*

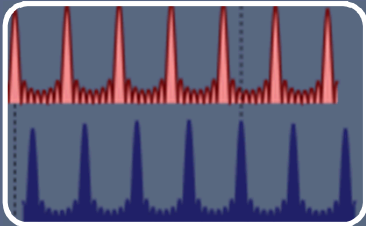


# Surface ion traps for quantum computing

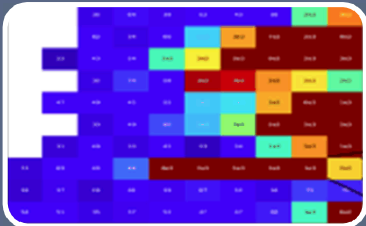
Dr. Daniel Stick



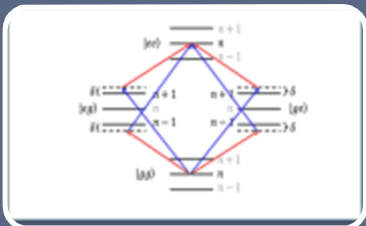
## Trap features



## Experimental characterization



## Single qubit gates

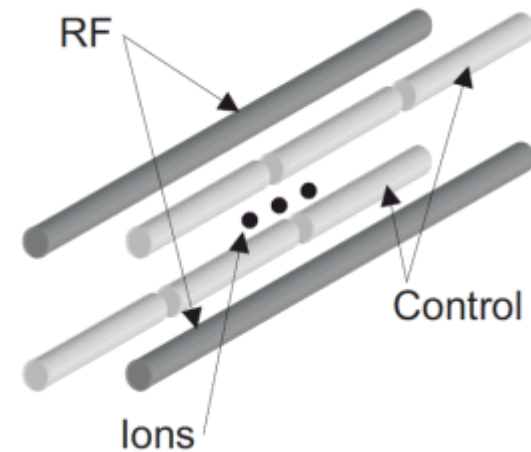


## Mølmer-Sørensen two-qubit gate

# Advantages/Challenges vs 3D

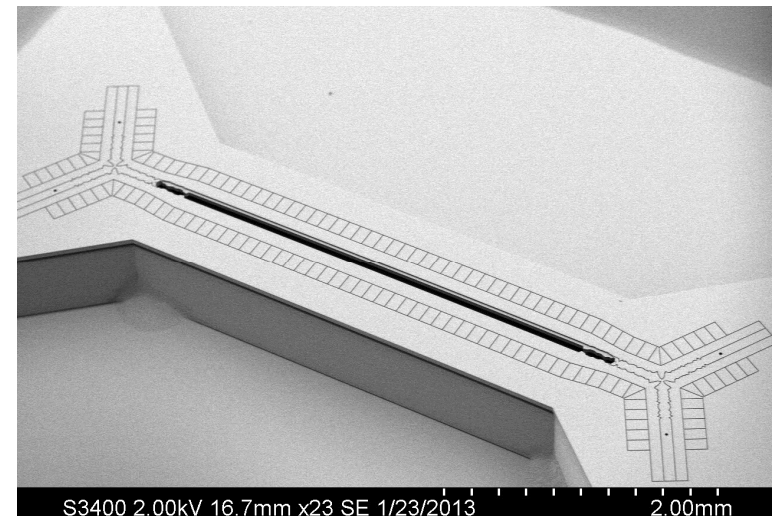
## Advantages

- More manufacturable (“scalable”)
- Consistent geometry -> consistent behavior
- Greater field control (more electrodes)
- 2D geometry
- Laser access
- Integration of other technologies (waveguides, detectors, filters...)



## Challenges

- Low depth (ion lifetime), anharmonicities
- Proximity to surface (charging, heating)
- Delicate (dust, voltage)
- Capacitance



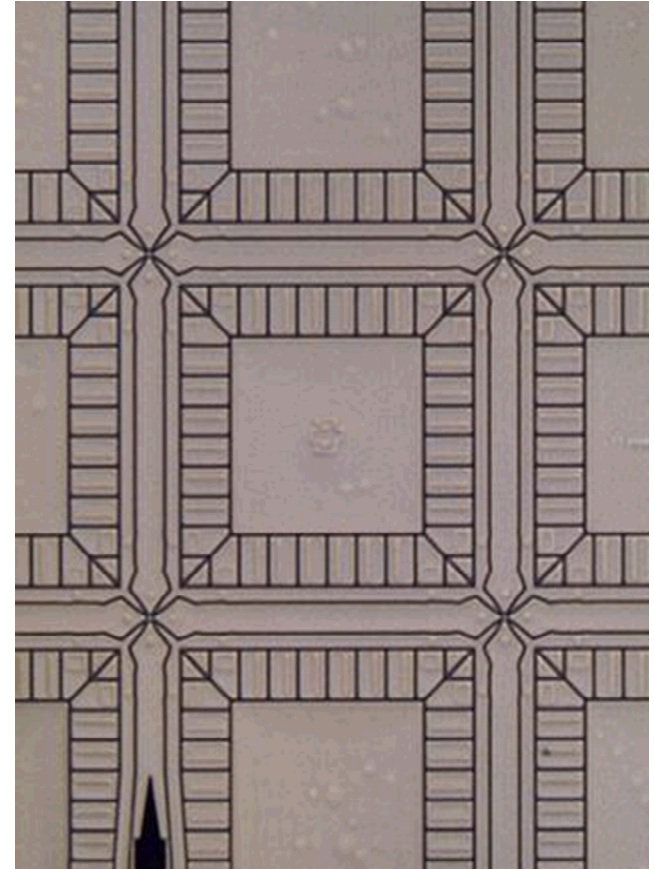
# Capabilities & Requirements

## Essential capabilities

- Store ions for long periods of time (hours)
- Move ions to achieve 2D connectivity
- Support high fidelity operations
- Uniform performance

## Derived requirements

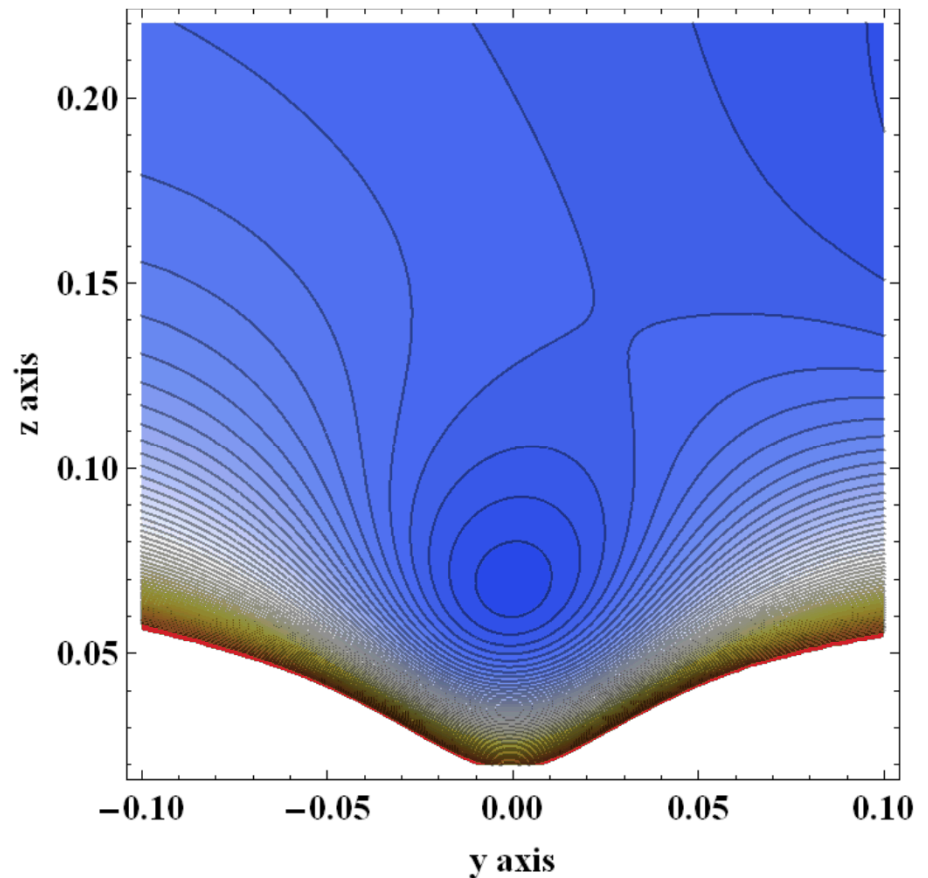
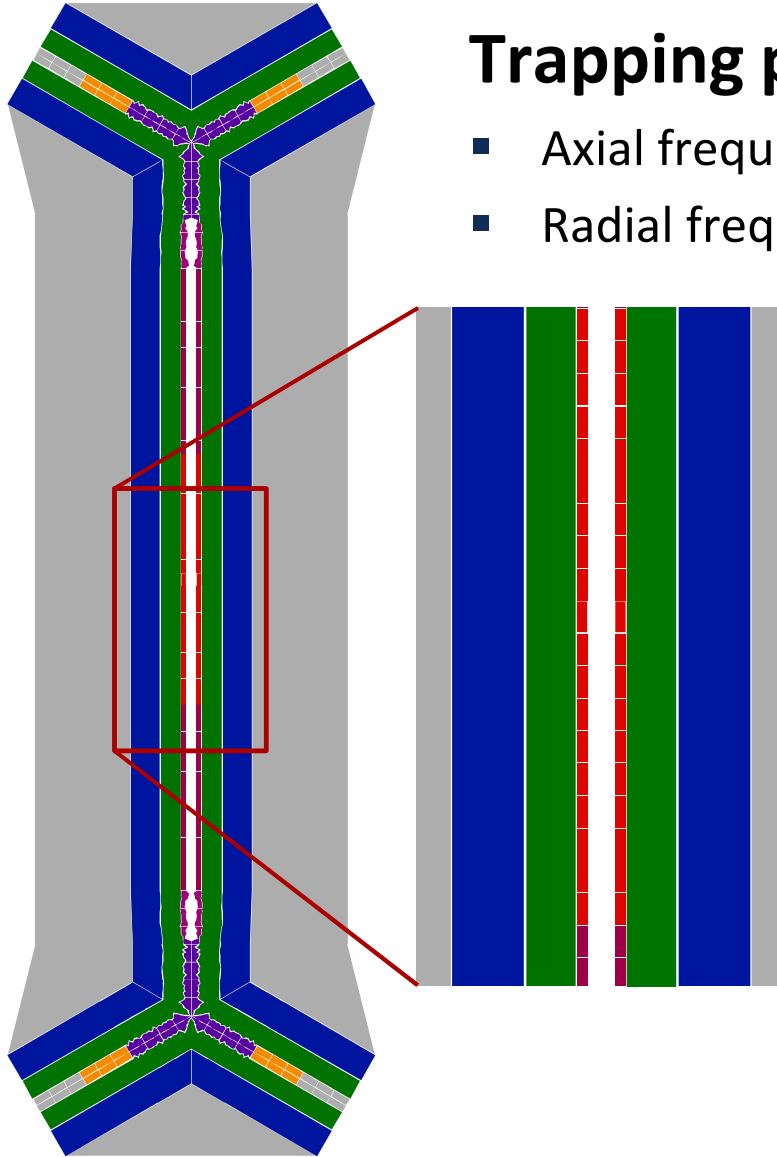
- Voltage breakdown  $>300$  V @  $\sim 50$  MHz
- Backside loading hole
- Multi-level lead routing for accessing interior electrodes
- Standardization [lithographically defined electrodes]
- Overhung electrodes [evaporated metal]
- High optical access [high NA delivery and collection optics]



# Voltage application

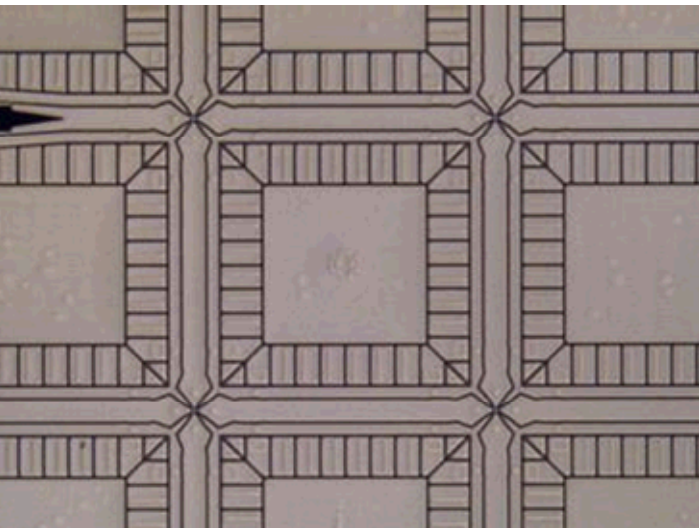
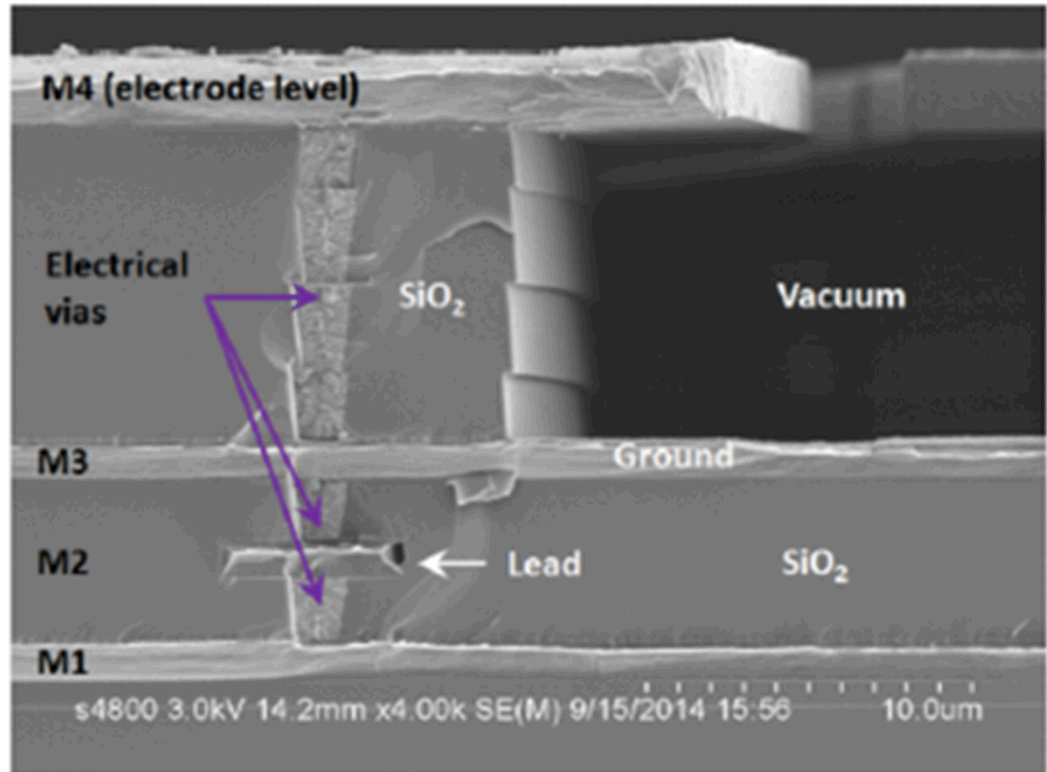
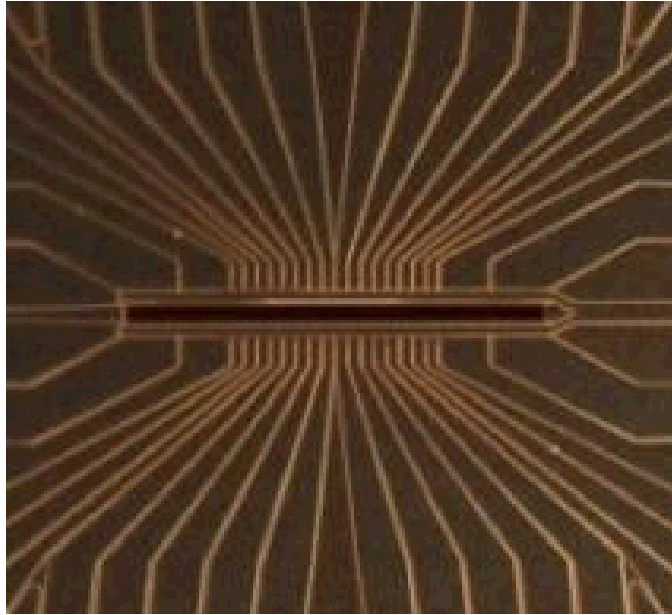
## Trapping potential

- Axial frequency: 500 kHz [ $<5$  V]
- Radial frequency: 2.8 MHz, 3.1 MHz [250 Vrf @ 40 MHz]

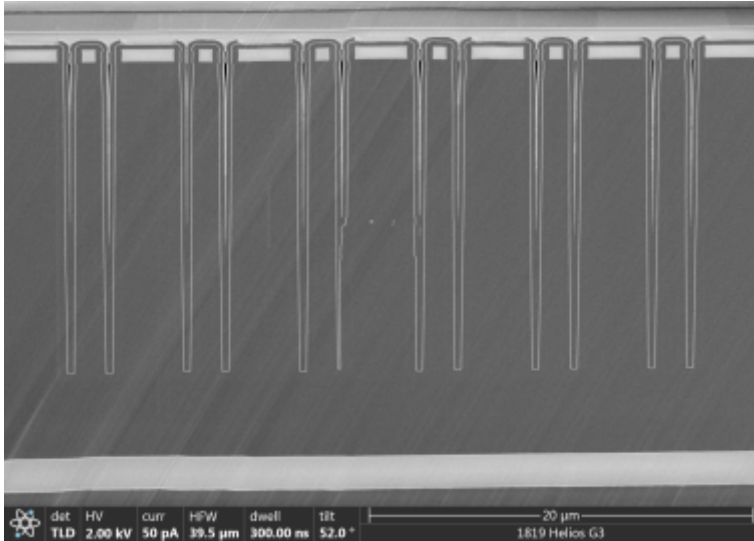




# Multi-layer metallization



# Trench capacitors & Loading holes



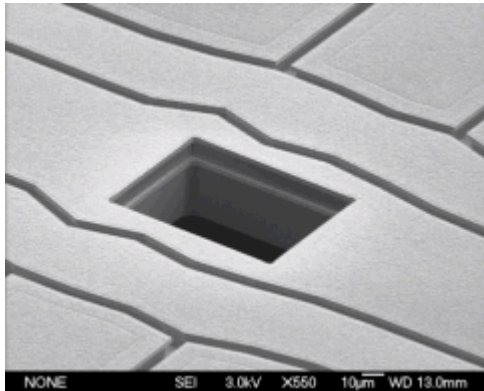
## Interposer (current)

- 20V max voltage
- 1nF capacitance

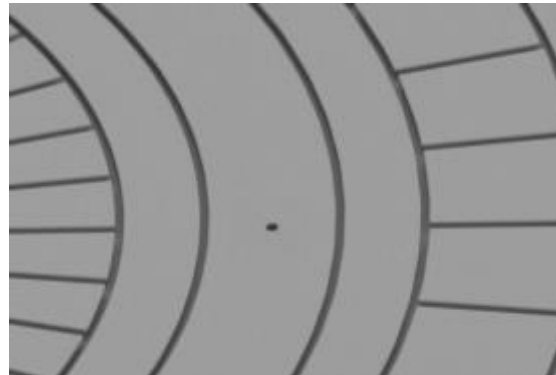
## On chip (future)

- 15V max voltage
- 200pF capacitance (but low inductance)
- Up to 200 capacitors can be located within the isthmus

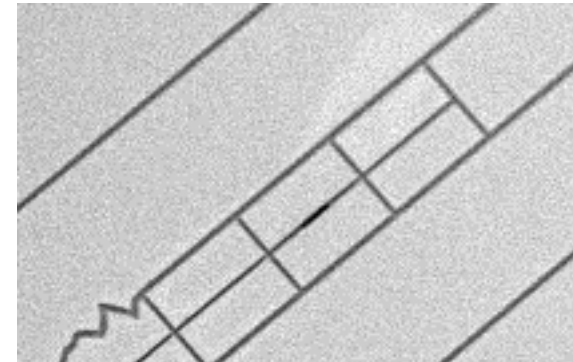
50μm×80μm  
*modulation necessary*



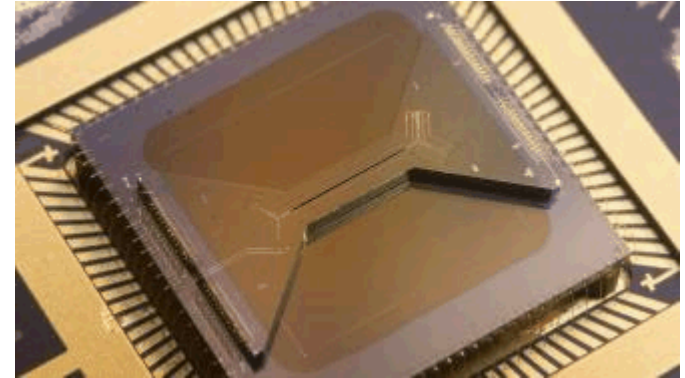
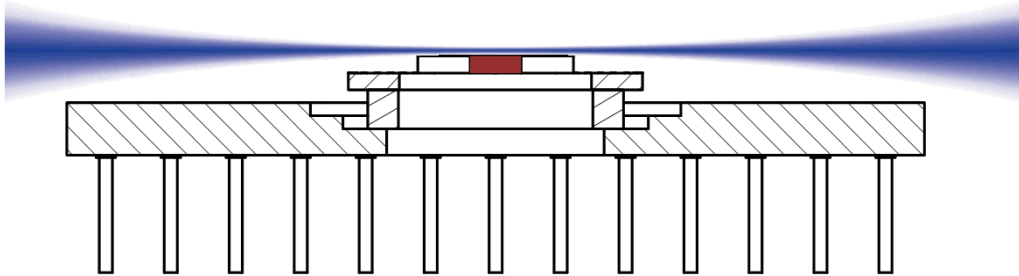
10μm hole  
*still perturbs the field*



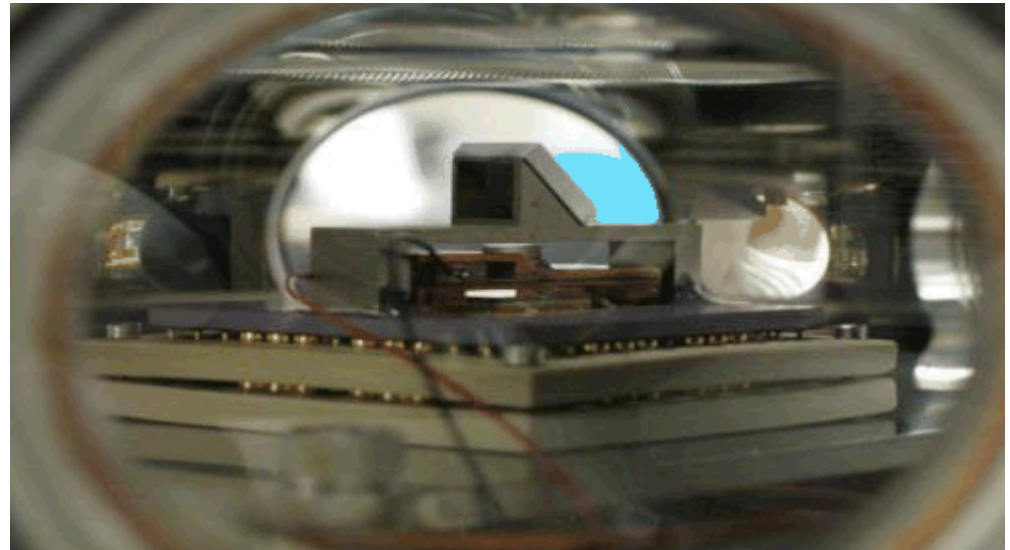
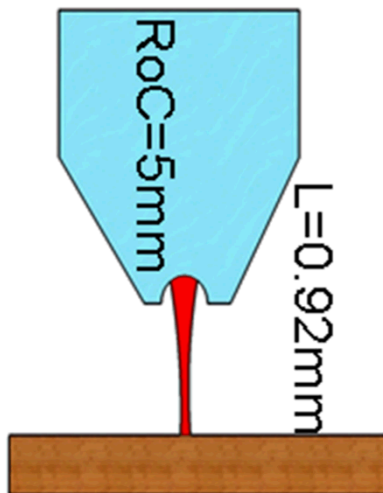
3μm×20μm



# Optical access & integrated optics



Can accommodate  $4/2 \text{ um}$  beam waist (369 nm)

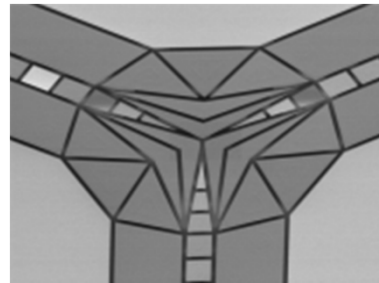
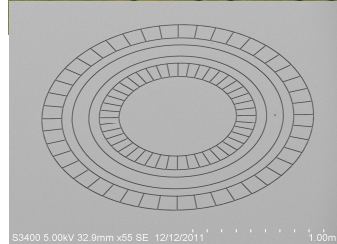
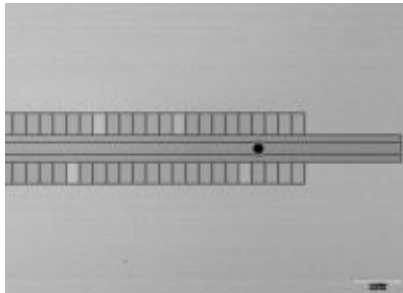
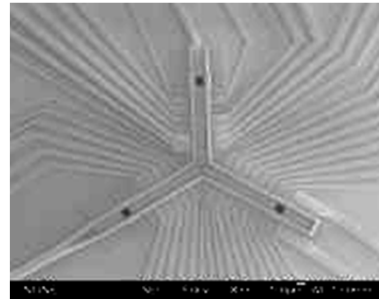
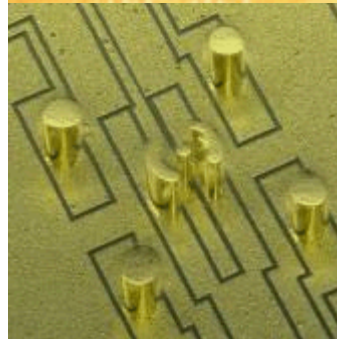
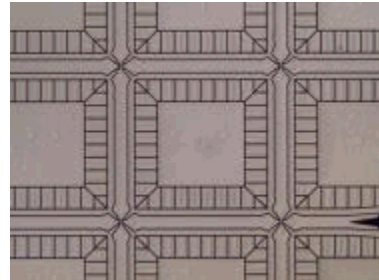
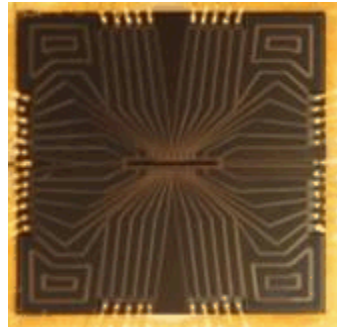
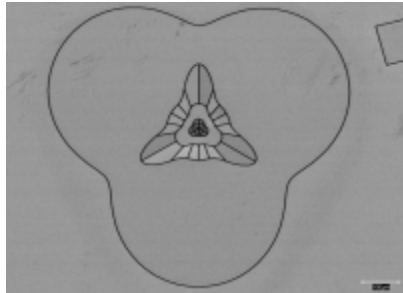




# Trap features

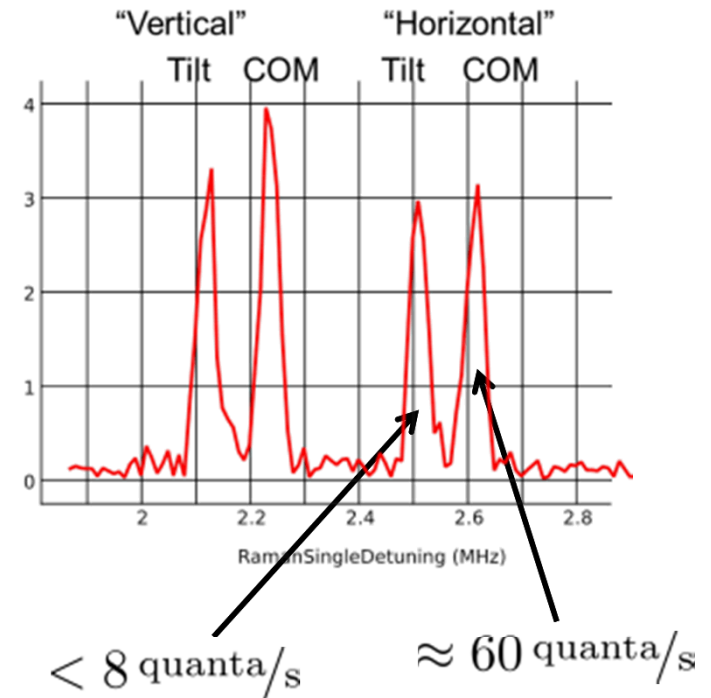
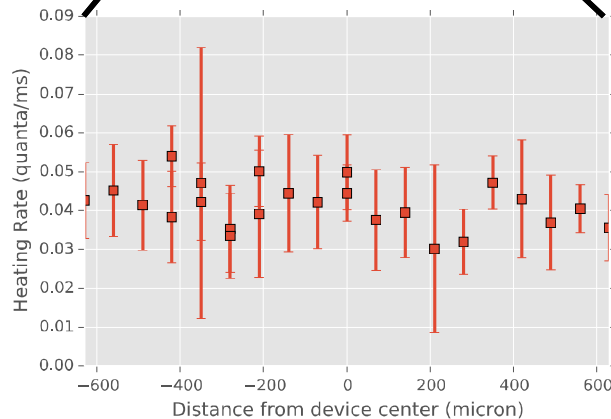
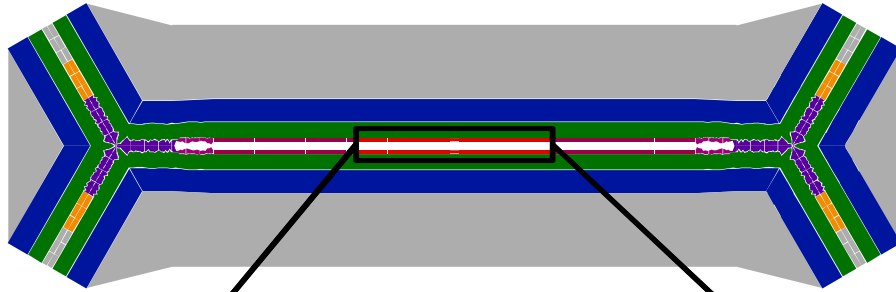
## Manufacturability, uniformity

- 12 institutions, 5 countries
- >100 devices delivered
- Quantum computing
- Quantum simulations
- Quantum communication
- Surface science
- Metrology



# Experimental characterization

## Heating

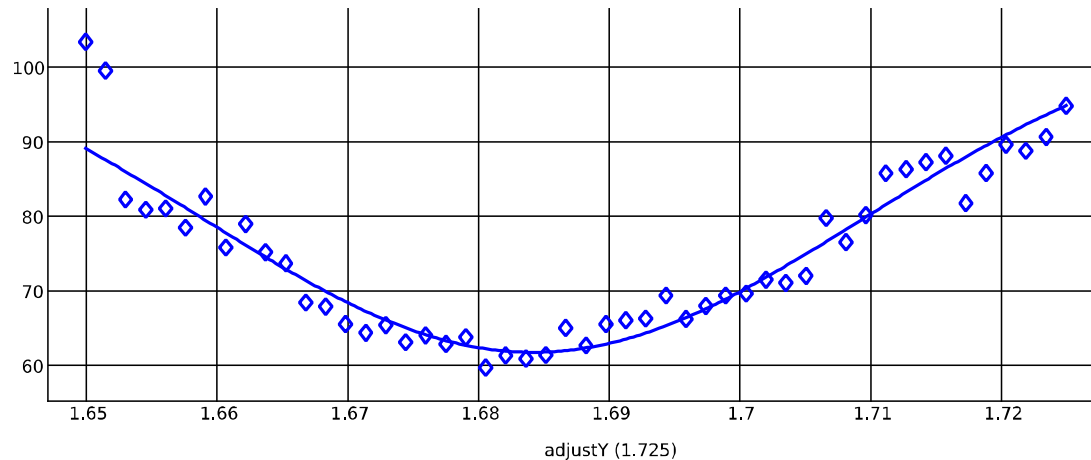
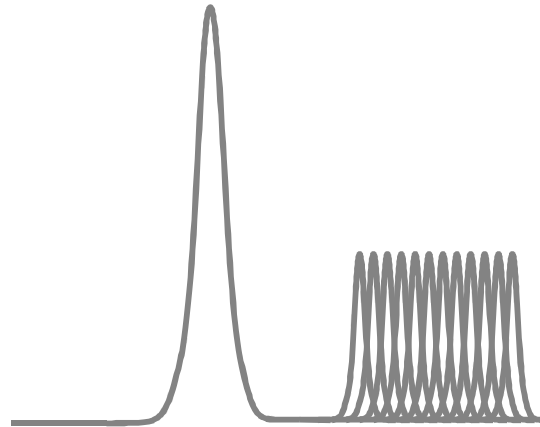
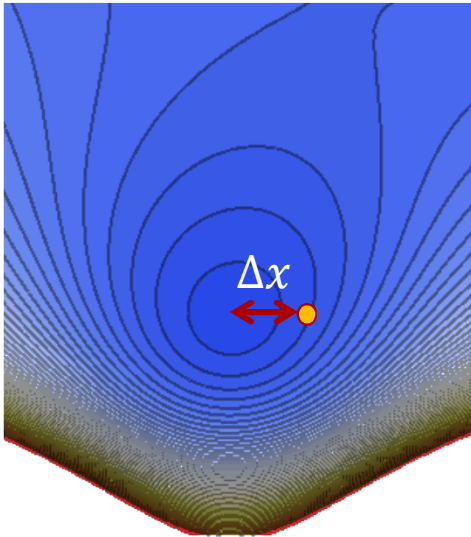


- Heating rate 40 q/s on average,  $^{171}\text{Yb}^+$ , Trap frequency 2.8 MHz, RF drive at 50 MHz
- Limited by technical noise:  $\dot{n}_{\parallel} = 30 \text{ quanta/s}$   
 $\dot{n}_{\perp} \approx 125 \text{ quanta/s}$
- Heating rate in HOA-2 is low and uniform along the length of the quantum section

# Experimental characterization

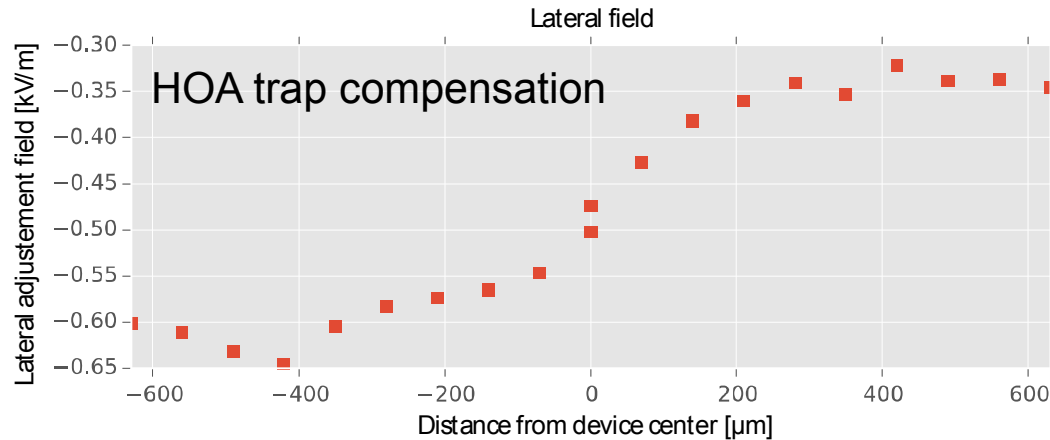
## Background electric field

$$x(t) = [A \cos(\omega t) + \Delta x] \left(1 + \frac{q}{2} \cos(\Omega t)\right)$$

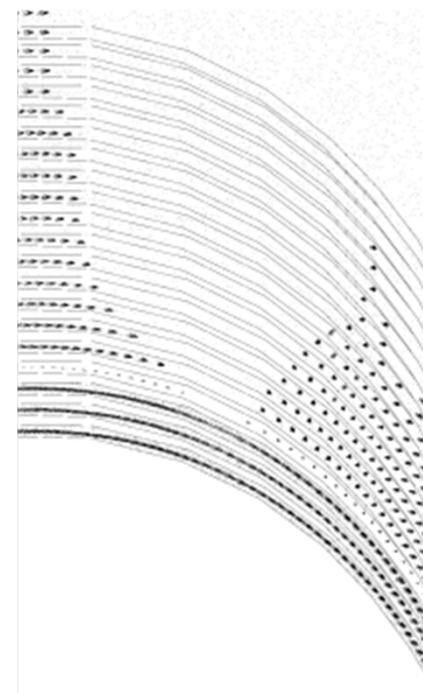
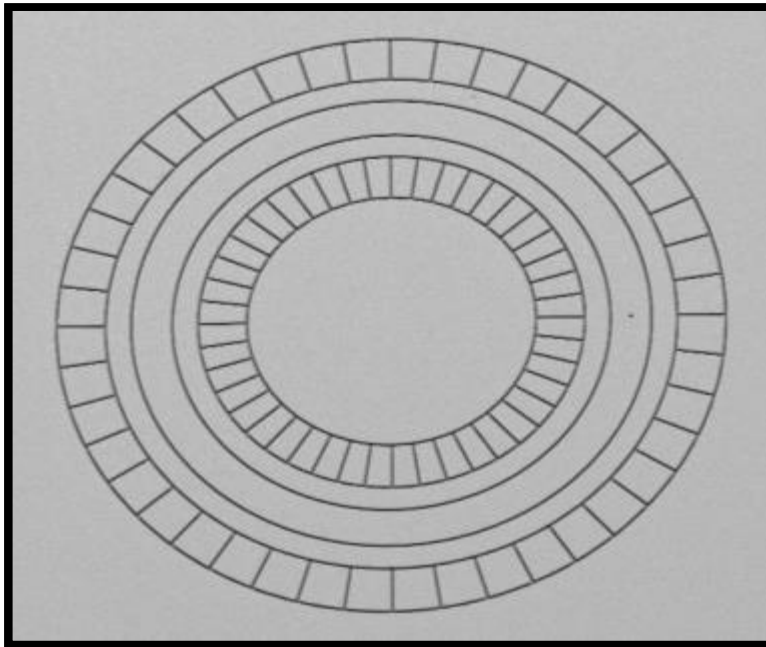


# Experimental characterization Background electric field

**Linear trap**



**Ring trap**



**correction**

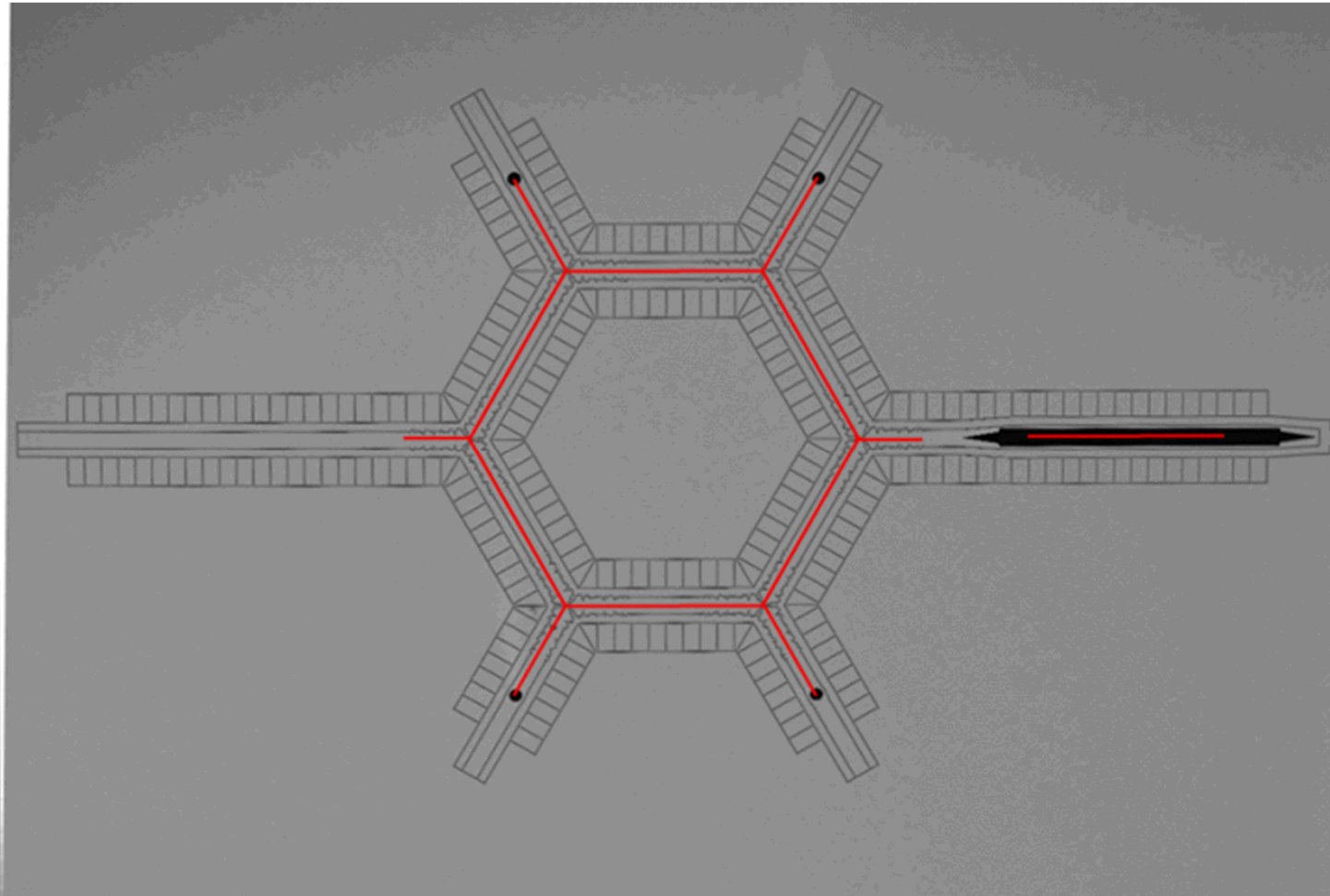
**0%**



**100%**

# *Experimental characterization* Shuttling and swapping

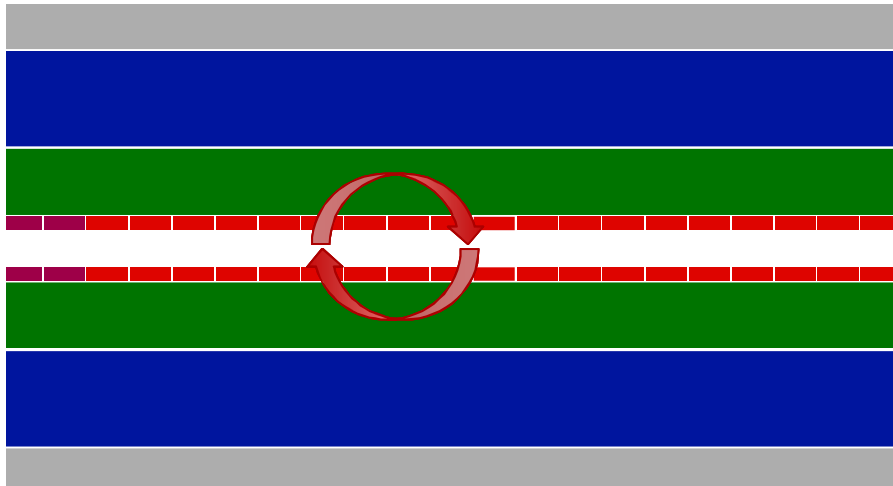
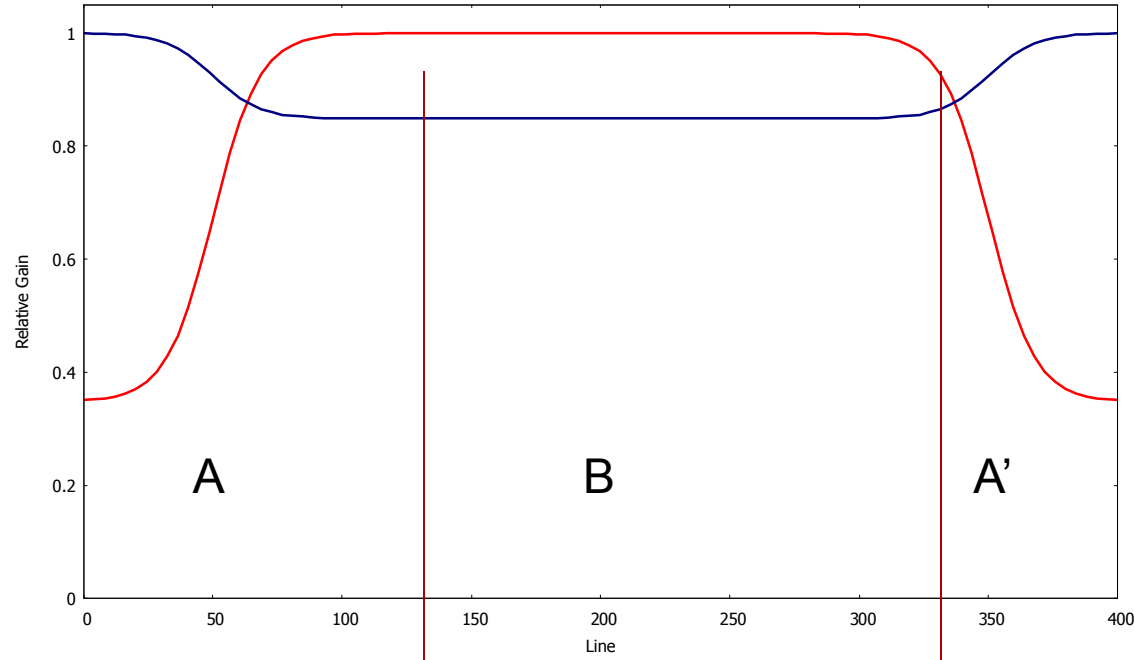
- Co-wired junction and linear sections, transported ions around device



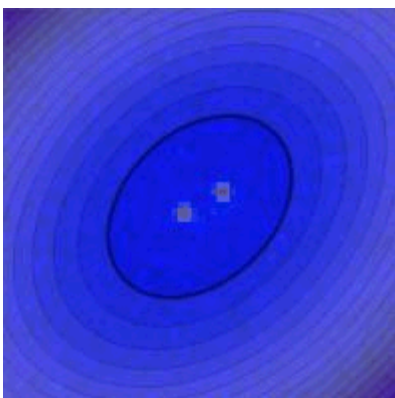
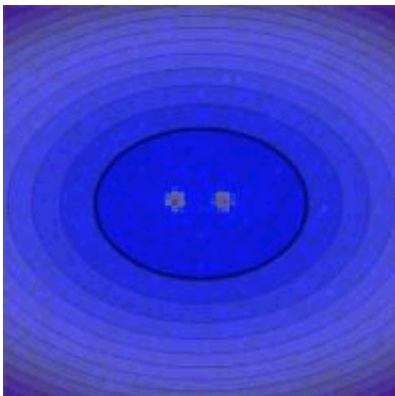


# Experimental characterization

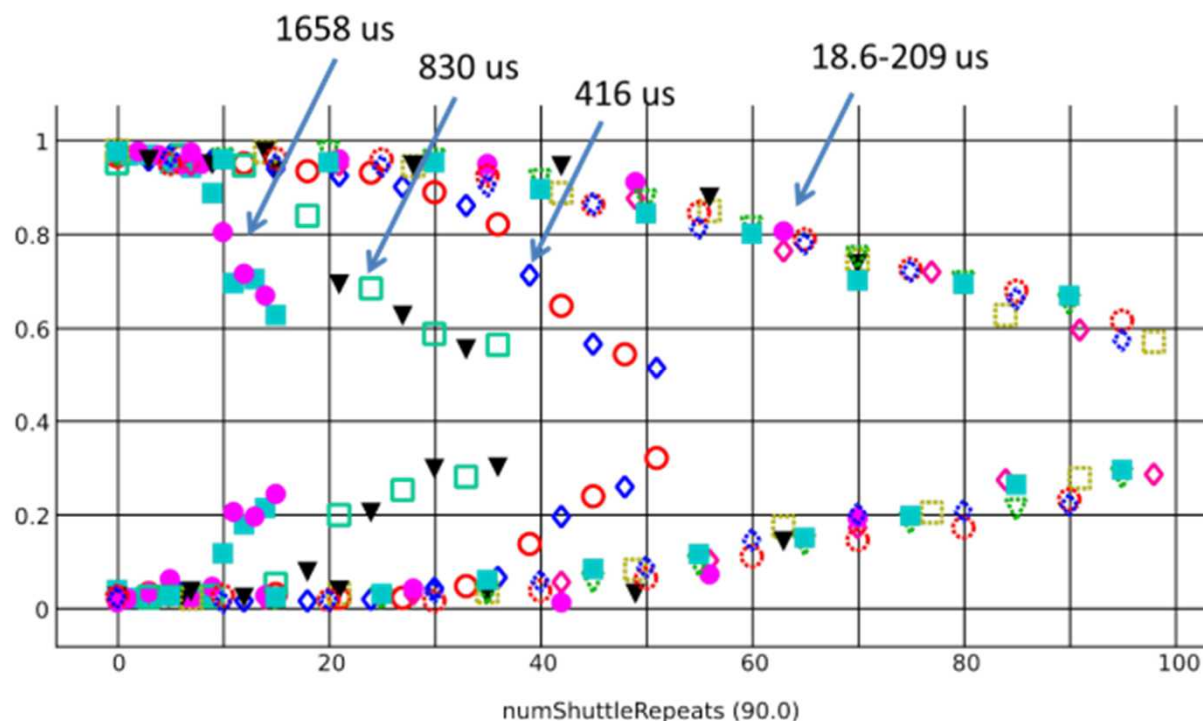
## Shuttling and swapping



# Experimental characterization Shuttling and swapping



- Tag one ion with BB1 compensated pulse
- Measure states on separate PMT's after rotation
  - In addition to declining success probability, fluorescence drops due to motional heating
  - Success probability drops for times  $< 18.6$   $\mu\text{s}$



# Gate Set Tomography (GST)

Desired “target” gates:

$G_i$  Idle (Identity)

$G_x$   $\pi/2$  rotation about  $x$ -axis

$G_y$   $\pi/2$  rotation about  $y$ -axis

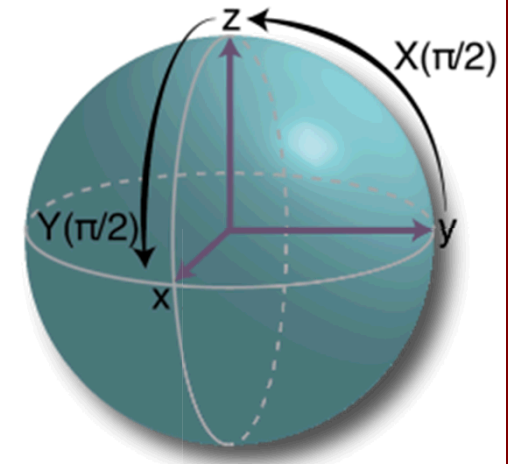
- No calibration required
- Detailed debug information
- Efficiently measures performance characterizing fault-tolerance (diamond norm)
- Amplifies errors
- Detects non-Markovian noise
- Robin Blume-Kohout, SNL

Fiducials:

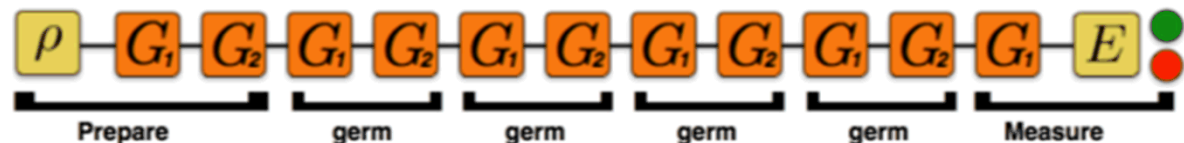
$\{$   
 $G_x$   
 $G_y$   
 $G_x \cdot G_x$   
 $G_x \cdot G_x \cdot G_x$   
 $G_y \cdot G_y \cdot G_y$

Germes:

$G_x$   
 $G_y$   
 $G_i$   
 $G_x \cdot G_y$   
 $G_x \cdot G_y \cdot G_i$   
 $G_x \cdot G_i \cdot G_y$   
 $G_x \cdot G_i \cdot G_i$   
 $G_y \cdot G_i \cdot G_i$   
 $G_x \cdot G_x \cdot G_i \cdot G_y$   
 $G_x \cdot G_y \cdot G_y \cdot G_i$   
 $G_x \cdot G_x \cdot G_y \cdot G_x \cdot G_y \cdot G_y$



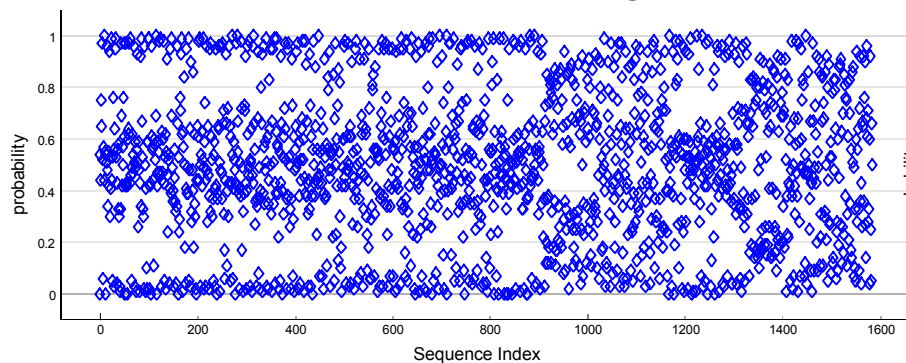
Single qubit BB1 compensated microwave gates on  $^{171}\text{Yb}^+$



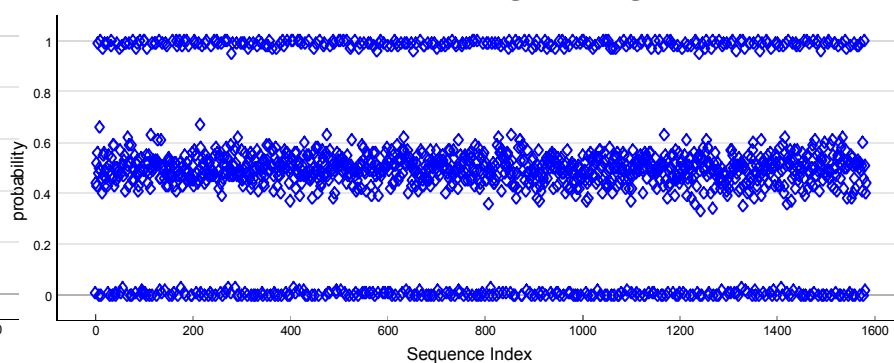
# Single qubit gates

## Microwave gates

Raw data poor gates

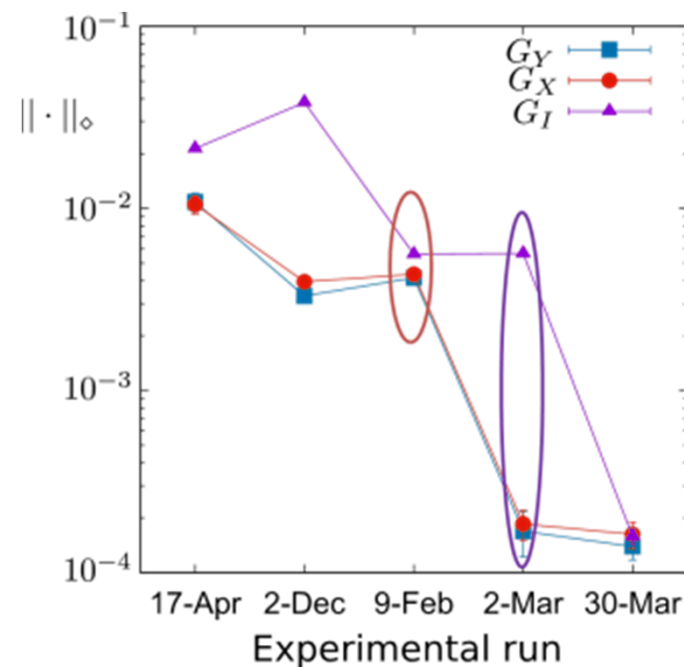


Raw data good gates



Gate	Rotn. axis	Angle
$G_I$	0.5252	$0.001699\pi$
	-0.009	
	0.8506	
	-0.0244	
$G_X$	$-3 \times 10^{-6}$	$0.501308\pi$
	-1	
	$-3 \times 10^{-5}$	
	-0.009	
$G_Y$	-0.2474	$0.501366\pi$
	0.0001	
	0.9689	
	-0.0001	

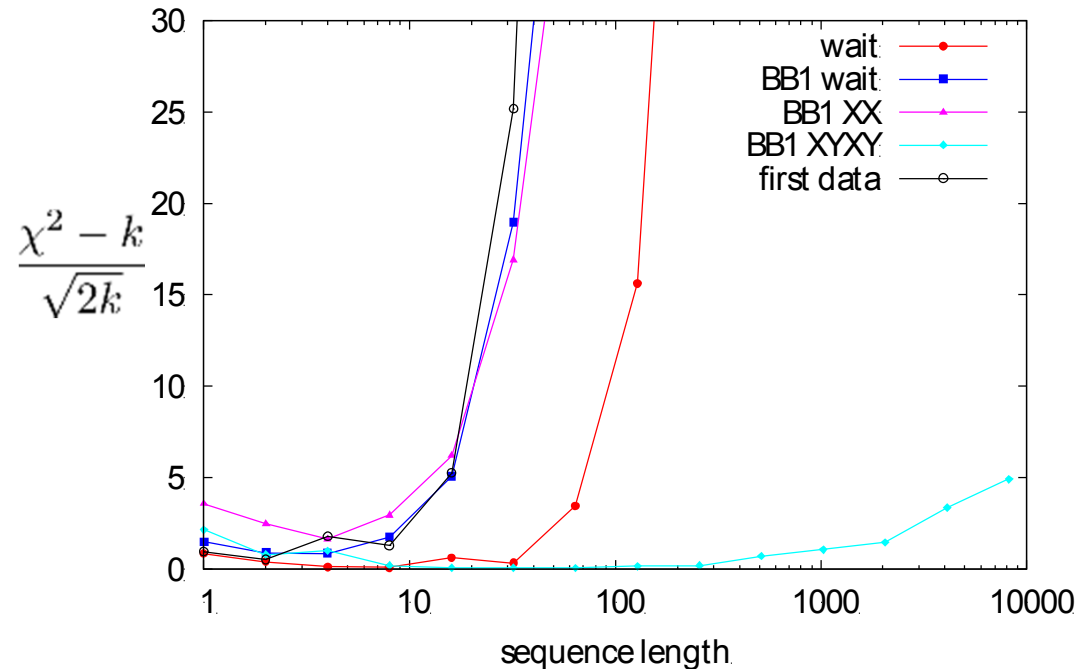
Gate	Rotn. axis	Angle
$G_I$	-0.0035	$0.001769\pi$
	0.014	
	-0.9999	
	0.0006	
$G_X$	$-3 \times 10^{-5}$	$0.500007\pi$
	-1	
	$1 \times 10^{-4}$	
	0.0006	
$G_Y$	0.1104	$0.50001\pi$
	$4 \times 10^{-5}$	
	0.9939	
	0.0005	



# Single qubit gates

## Markovianity violation

- BB1 decoupled microwave gates with decoupled identity have very small non-Markovian noise
- BB1 dynamically compensated pulse sequences
- Decoupling sequence for identity gate
- Drift control for  $\pi$ -time and qubit frequency



Gate	Process Infidelity	$1/2 \diamond$ -Norm
$G_I$	$6.9(6) \times 10^{-5}$	$7.9(7) \times 10^{-5}$
$G_X$	$6.1(7) \times 10^{-5}$	$7.0(15) \times 10^{-5}$
$G_Y$	$7.2(7) \times 10^{-5}$	$8.1(15) \times 10^{-5}$

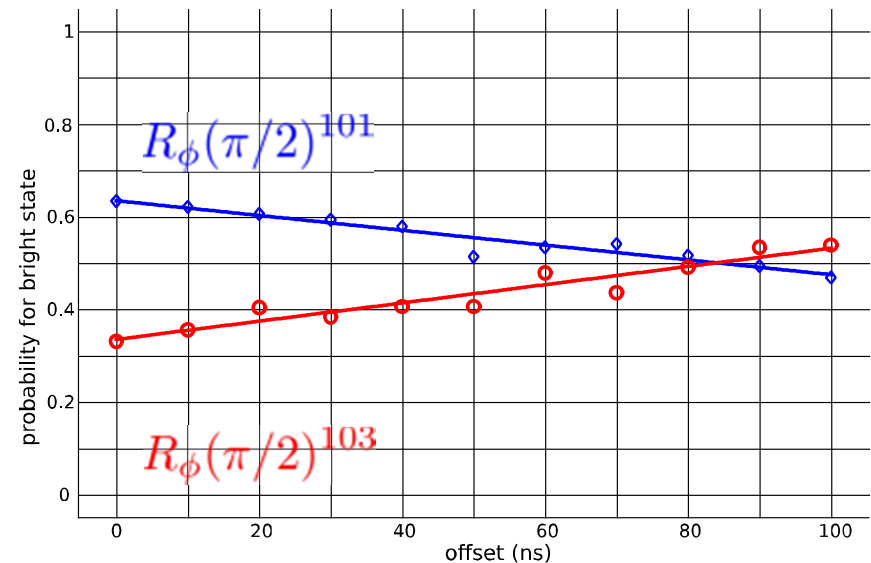
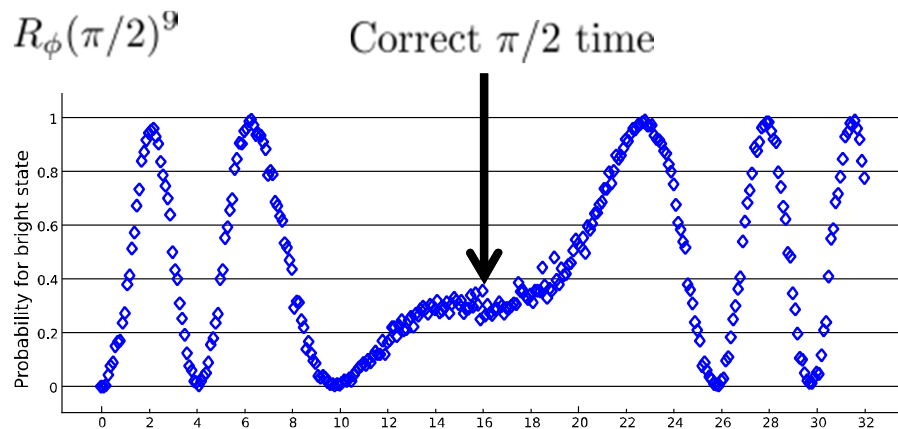
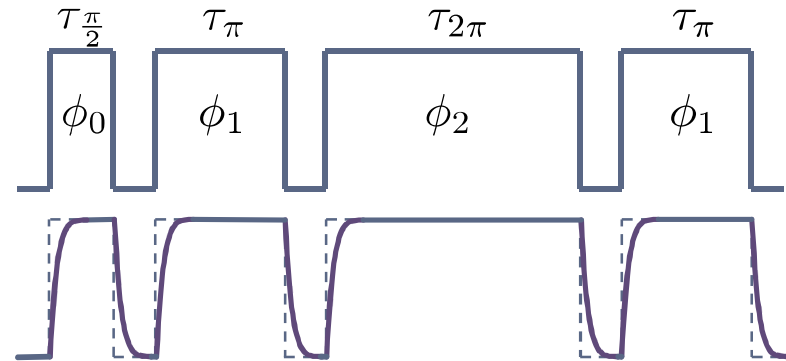
95% confidence intervals



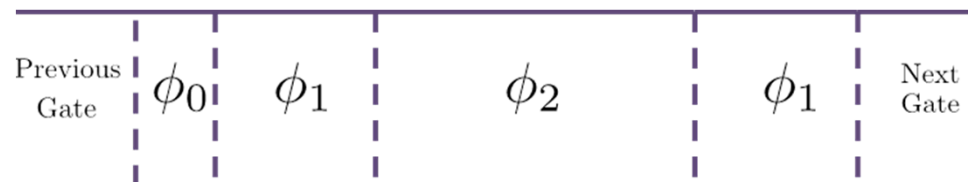
# Microwave broadband pulses

BB1 compensated pulse

Switching artifacts



Discontinuous phase updates are used in place of gaps. Solves issues related to finite turn-on time and allows for continuous feedback on the driving field power.



# Microwave error sources

- Time resolution:
  - Current time resolution is 5 ns
  - $\pi$ -times are 45  $\mu$ s
  - ratio:  $10^{-4}$
  - Possible due to broadband pulses
- Coherence time:
  - $T_2^* = 1$  s
  - longest pulse sequences 8192 : 1.66 s

# *GST: Raman laser results*



co-propagating beam geometry

- Motion independent
- No optical phase imprinted

- BB1 dynamically compensated pulse sequences

## GST results:

95% confidence intervals

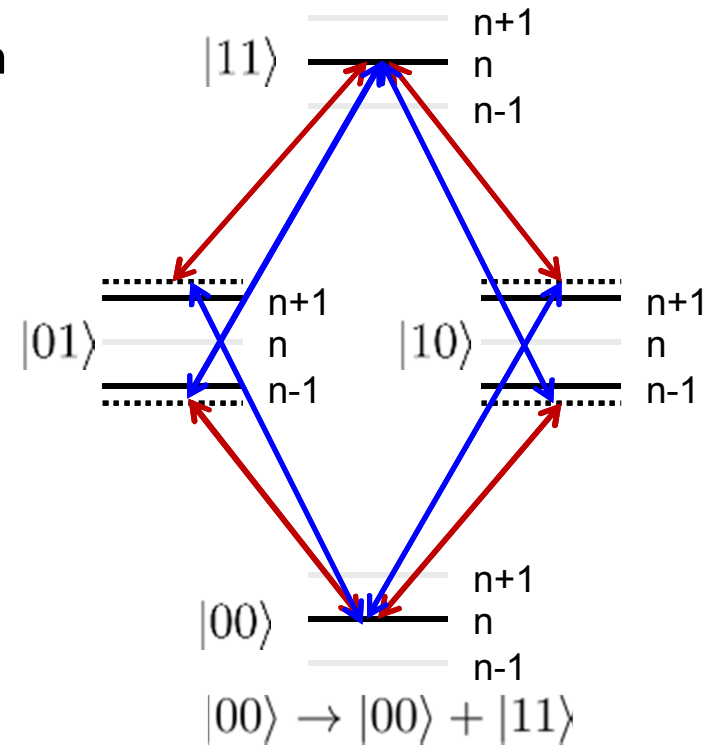
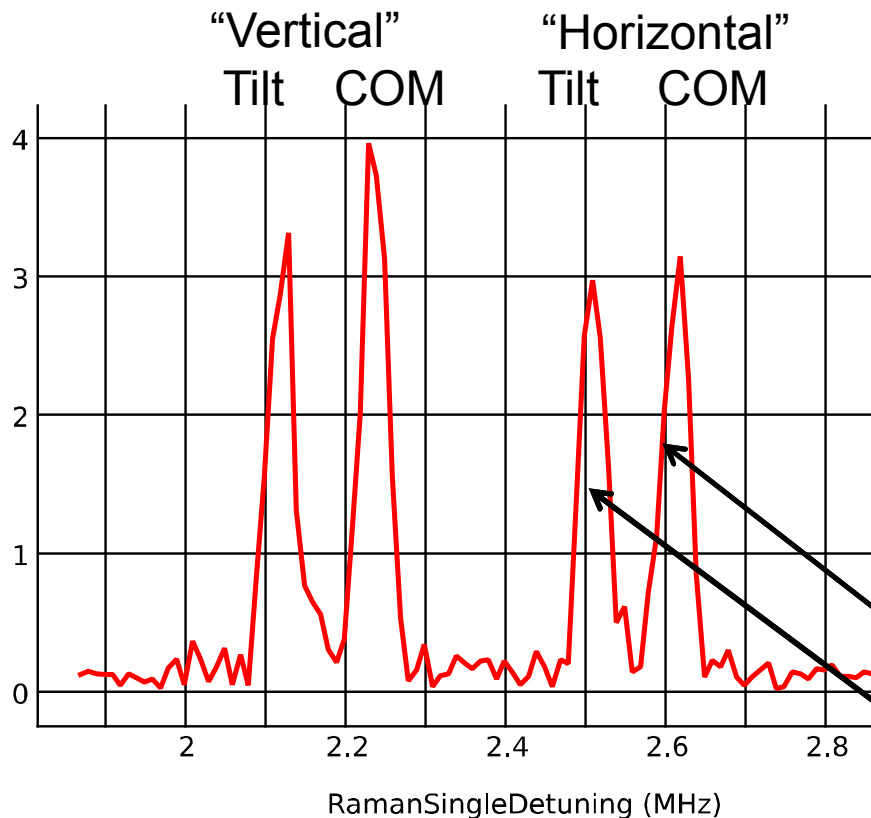
Gate	Conventional pulses		Gapless pulses	
	Process Infidelity	$1/2 \diamond$ -Norm	Process Infidelity	$1/2 \diamond$ -Norm
$G_I$	$0.05(2) \times 10^{-4}$	$12(1) \times 10^{-4}$	$1.1(1) \times 10^{-4}$	$5.3(2) \times 10^{-4}$
$G_X$	$1.3(1) \times 10^{-4}$	$4(2) \times 10^{-4}$	$0.5(1) \times 10^{-4}$	$2(6) \times 10^{-4}$
$G_Y$	$1.6(4) \times 10^{-4}$	$4(3) \times 10^{-4}$	$0.7(1) \times 10^{-4}$	$4(9) \times 10^{-4}$

$$\begin{aligned} \text{Process Infidelity} &< 1.2 \times 10^{-4} \\ 1/2 \diamond\text{-Norm} &< 5.5 \times 10^{-4} \end{aligned}$$

# Two qubit gates

## Mølmer-Sørensen gates

- Mølmer-Sørensen gates [1]
- All two-qubit gates implemented using Walsh compensation pulses [2]



Heating rates

$\approx 60$  quanta/s

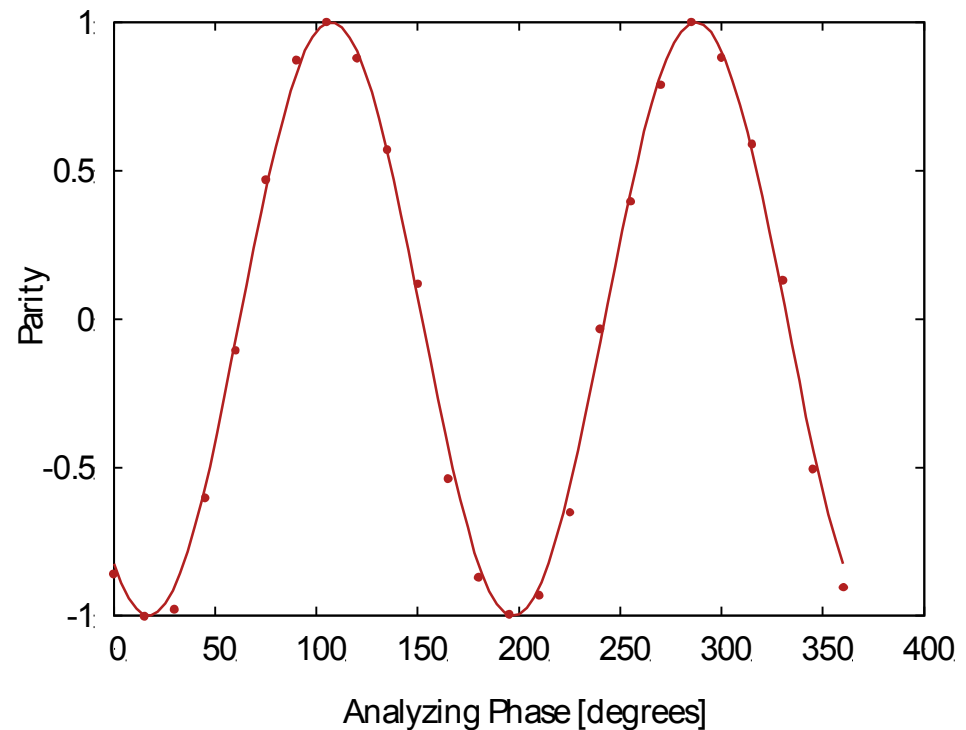
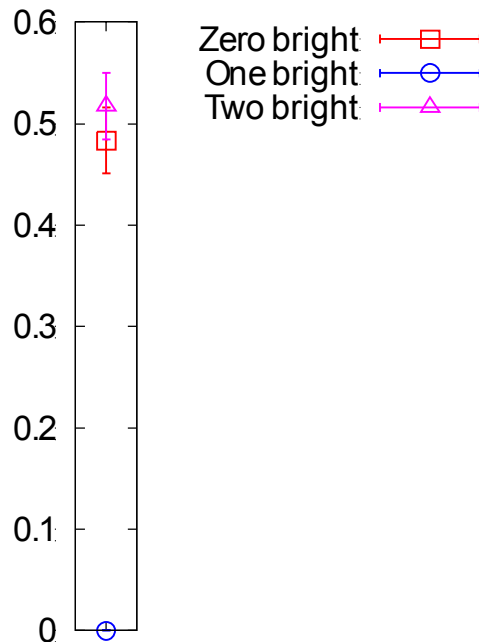
$< 8$  quanta/s

[1] K. Mølmer, A. Sørensen, PRL 82, 1835 (1999)

[2] D. Hayes et al. Phys. Rev. Lett. 109, 020503 (2012)

# Fidelity measurement using parity scan

- Implemented using Walsh compensation pulses
- Optical phase sensitive



$$\mathcal{F} = \frac{1}{2}(P(|00\rangle) + P(|11\rangle)) + \frac{1}{4}c \approx 0.995$$



# Two qubit gates GST on symmetric subspace



Basic gates:  $G_I$

$$G_{XX} = G_X \otimes G_X$$

$$G_{YY} = G_Y \otimes G_Y$$

$$G_{MS}$$

Preparation Fiducials:

$\{\}$

$G_{XX}$

$G_{YY}$

$G_{MS}$

$G_{XX}G_{MS}$

$G_{YY}G_{MS}$

Germs:

$G_I$

$G_{XX}$

$G_{YY}$

$G_{MS}$

$G_I G_{XX}$

$G_I G_{YY}$

$G_I G_{MS}$

$G_{XX}G_{YY}$

$G_{XX}G_{MS}$

$G_{YY}G_{MS}$

$G_I G_I G_{XX}$

$G_I G_I G_{YY}$

Detection Fiducials:

$\{\}$

$G_{XX}$

$G_{YY}$

$G_{MS}$

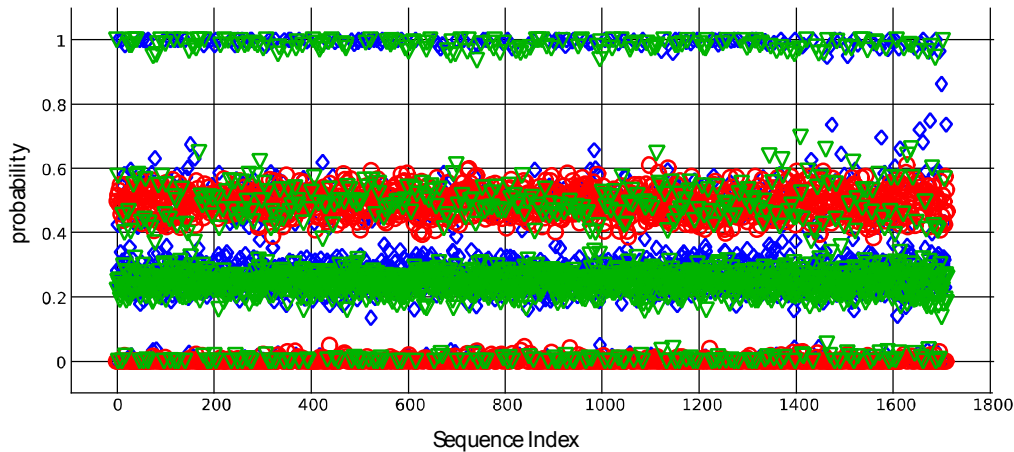
$G_{XX}G_{MS}$

$G_{YY}G_{MS}$

$G_{XX}^3$

$G_{YY}^3$

$G_{YY}^2 G_{MS}$



Zero ions bright  
One ion bright  
Two ions bright

Gate	Process infidelity	$\frac{1}{2}$ Diamond norm
$G_I$	$1.6 \times 10^{-3} \pm 1.6 \times 10^{-3}$	$28 \times 10^{-3} \pm 7 \times 10^{-3}$
$G_{XX}$	$0.4 \times 10^{-3} \pm 1.0 \times 10^{-3}$	$27 \times 10^{-3} \pm 5 \times 10^{-3}$
$G_{YY}$	$0.1 \times 10^{-3} \pm 0.9 \times 10^{-3}$	$26 \times 10^{-3} \pm 4 \times 10^{-3}$
$G_{MS}$	$4.2 \times 10^{-3} \pm 0.6 \times 10^{-3}$	$38 \times 10^{-3} \pm 5 \times 10^{-3}$

95% confidence intervals

Process fidelity of two-qubit Mølmer-Sørensen gate > 99.5%

# Acknowledgements



## Funding



## Collaborators



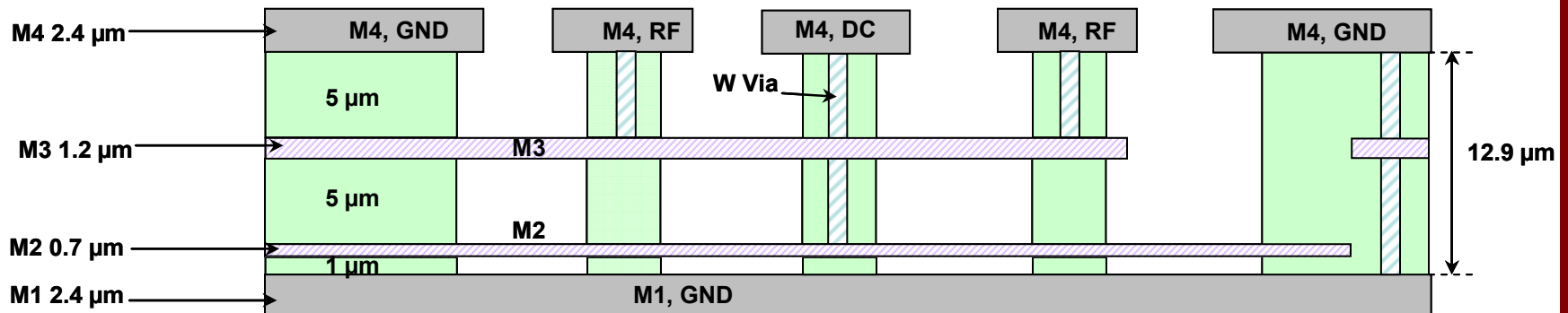
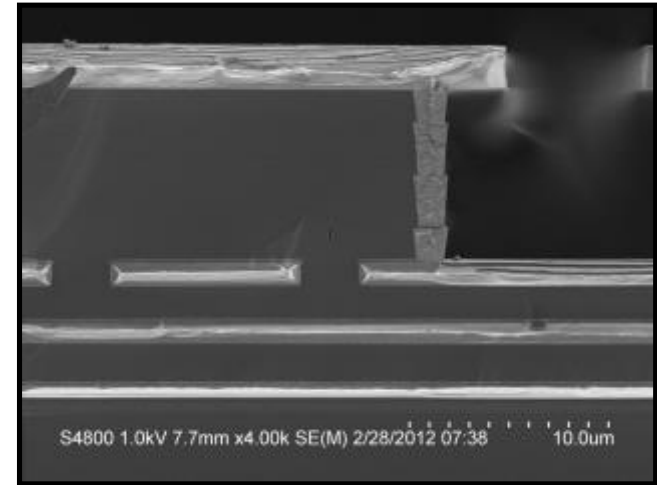
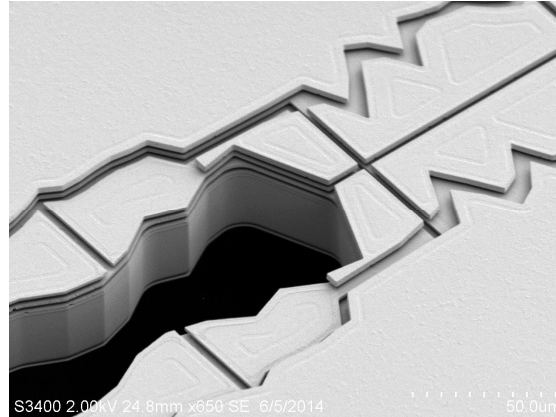
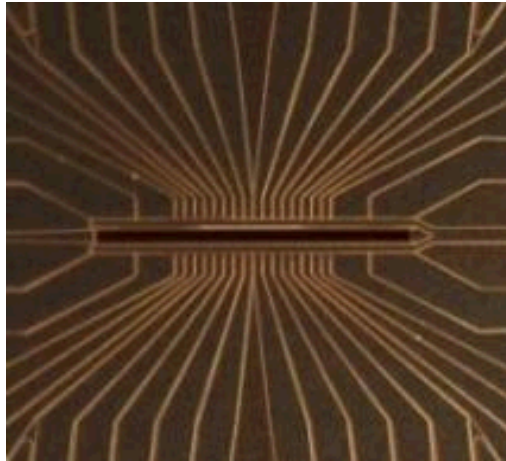


*Daniel Stick, Robin Blume-Kohout, M. G. Blain, C. Clark,  
S. Clark, K. Fortier, R. Haltli, E. Heller, C. Hogle, A. Hollowell, D.  
Lobser, P. Maunz, J. Mizrahi, E. Nielsen, P. Resnick, J. Rembetski, K.  
Rudinger, J. D. Sterk, C. Tigges, J. Van Der Wall.*



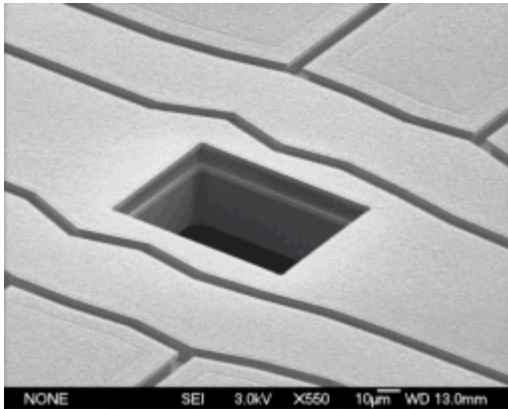


# Multi-layer metalization



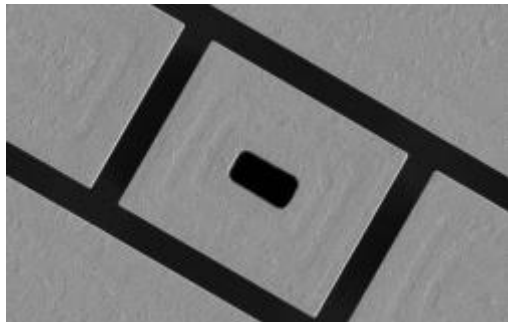
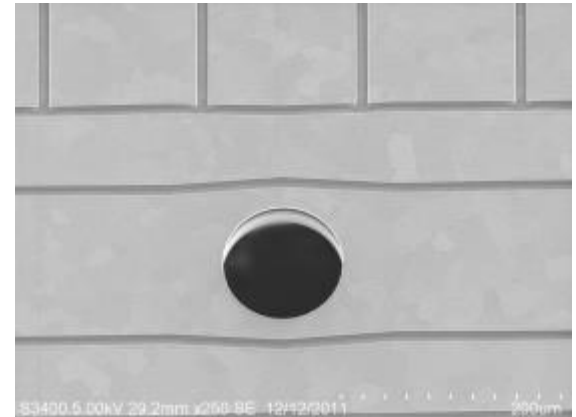
# Trap features

## Loading holes



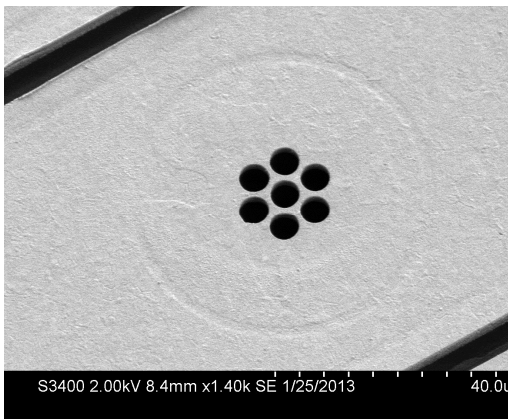
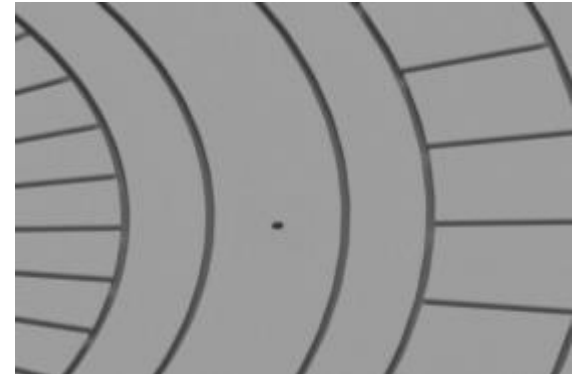
50µm×80µm  
*modulation necessary*

100µm diameter  
*modulation necessary*



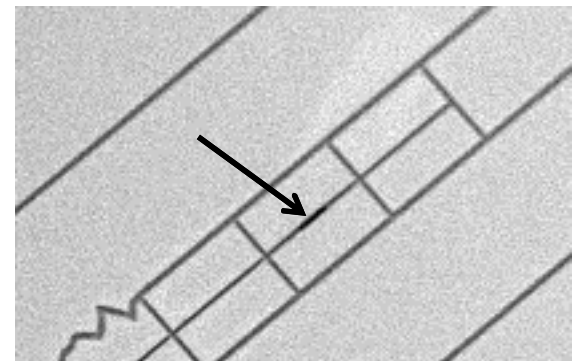
small rectangular hole  
*no modulation needed*

10µm hole  
*still perturbs the field*

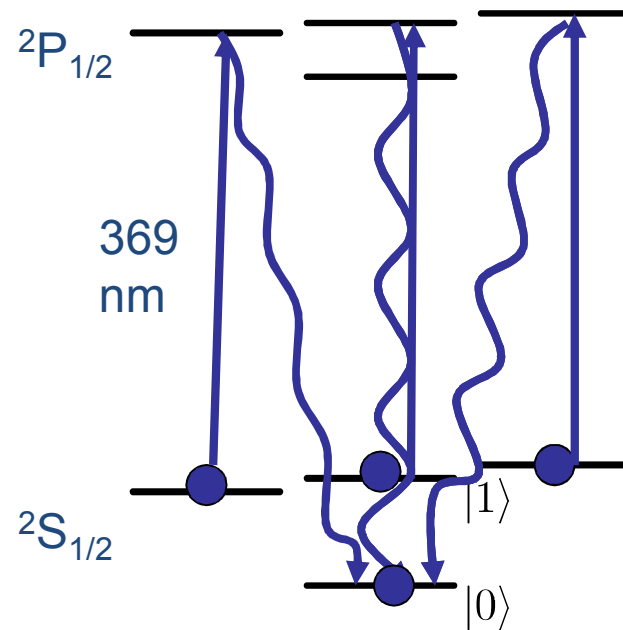
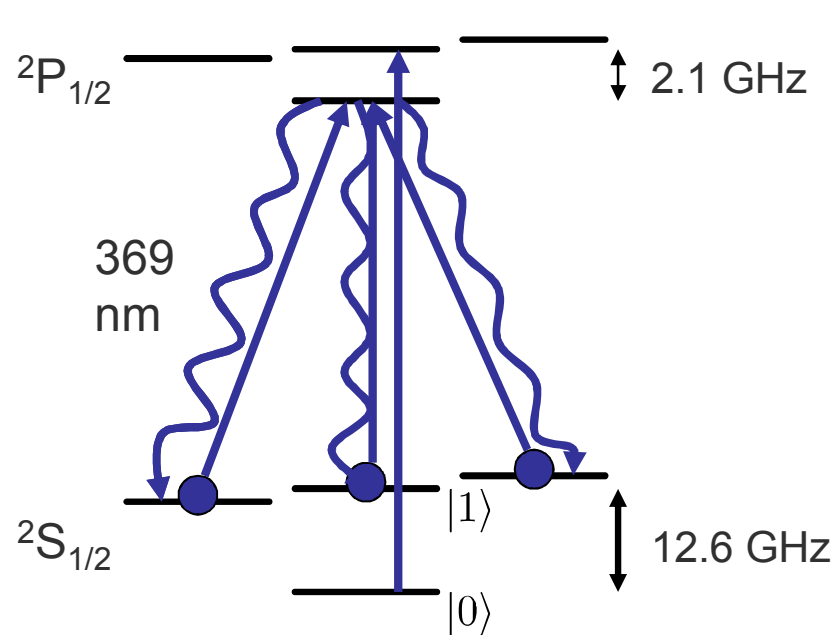


5µm holes  
*no modulation*

3µm×20µm



# Ytterbium qubit



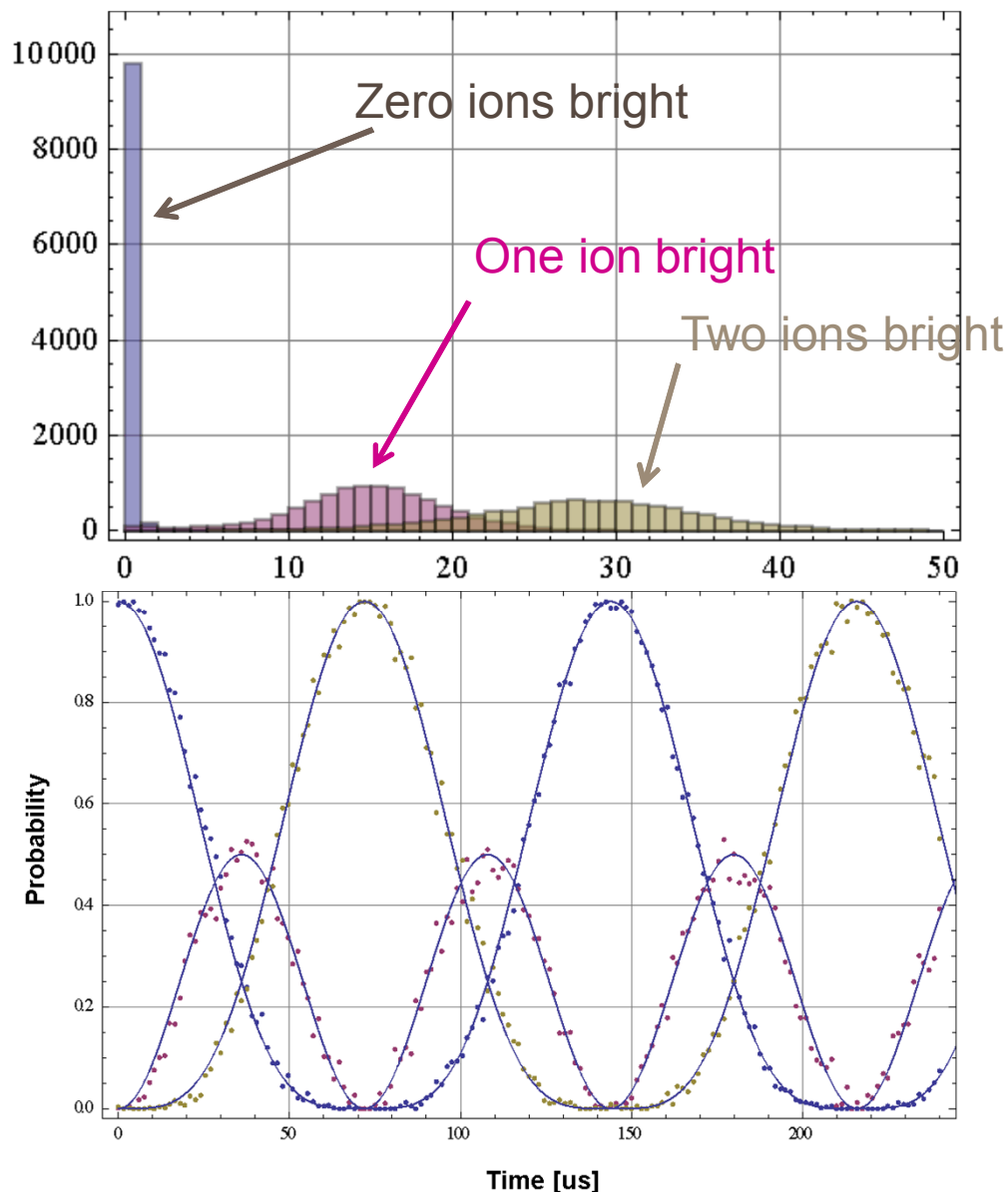
clock state qubit, magnetic field insensitive

# State detection for two ions

- Too much overlap between histograms of 1 and 2 bright ions
- Fit sums of experimentally measured 0, 1 and 2 ion bright histograms to determine probabilities of ensemble

## Demonstration:

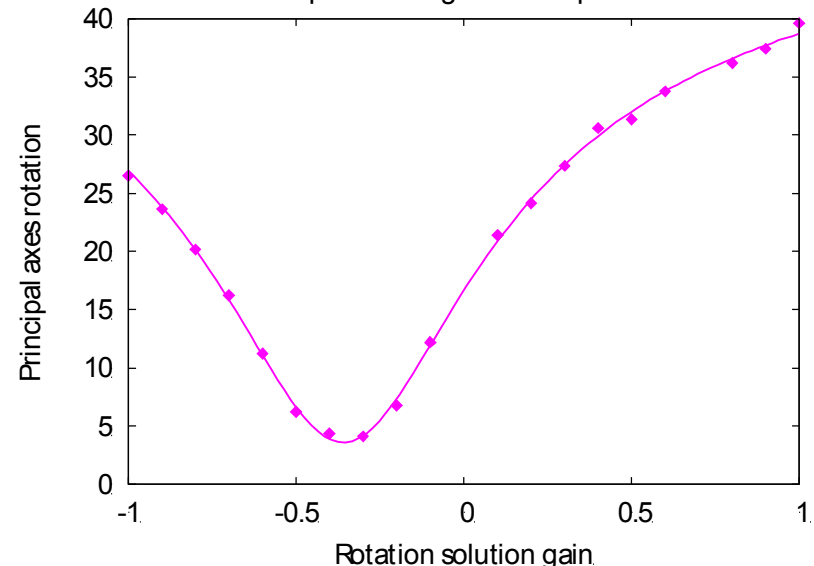
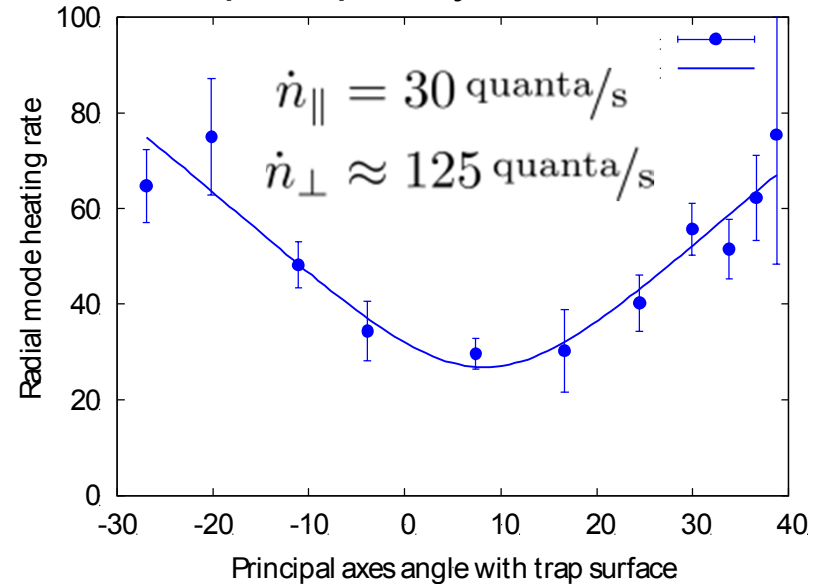
- Two trapped ions undergoing global Rabi oscillations
- Is described using one fit parameter: the  $\pi$ -time



## Heating rates as function of principal axes rotation

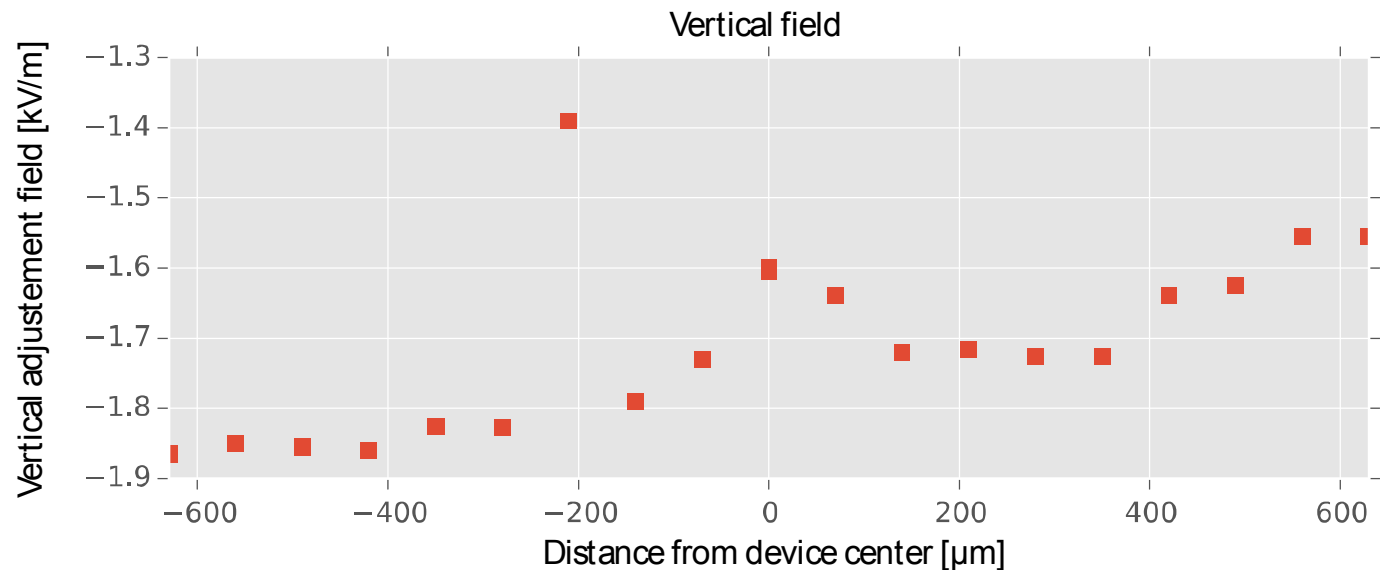
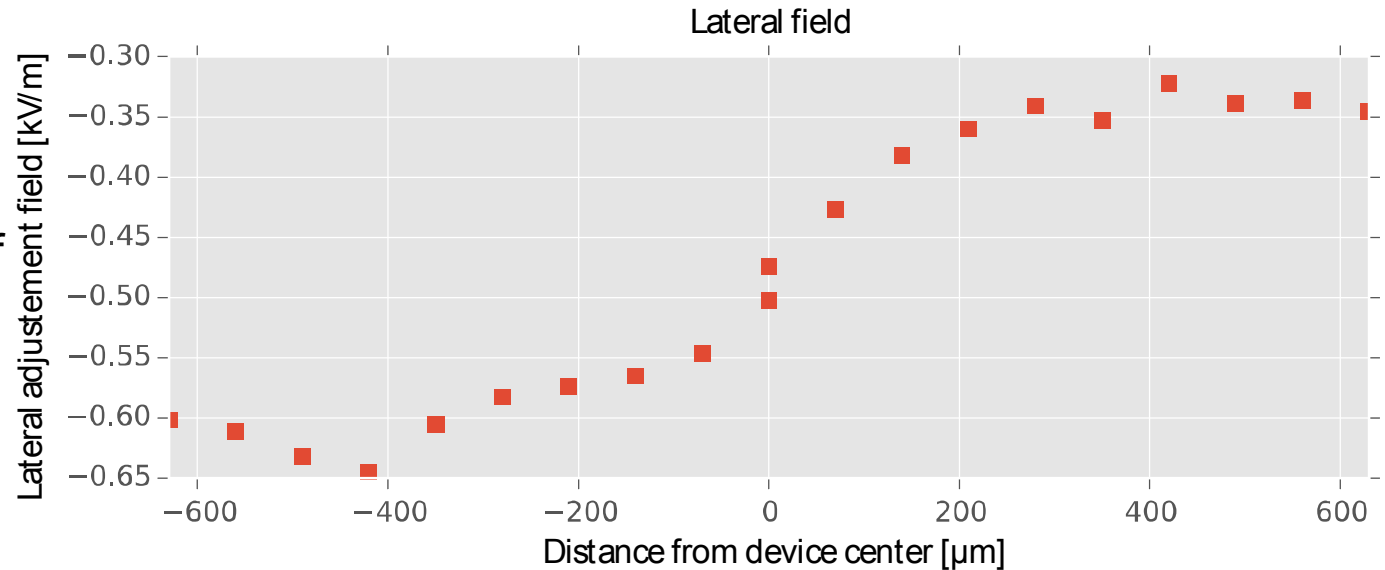
- Principal axes rotation measured by measuring  $\pi$ -times of Rabi flopping on cooled motional modes
- Minimal heating rates for motional mode parallel to trap surface  $\dot{n}_{\parallel}$
- Without technical noise: Vertical mode has at most  $\dot{n}_{\perp} \leq 2\dot{n}_{\parallel}$   
(P. Schindler, et al., Phys. Rev. A **92**, 013414 (2015)).
- Limited by technical noise

$^{171}\text{Yb}^+$ , Trap frequency 2.8 MHz, r.f. 50 MHz



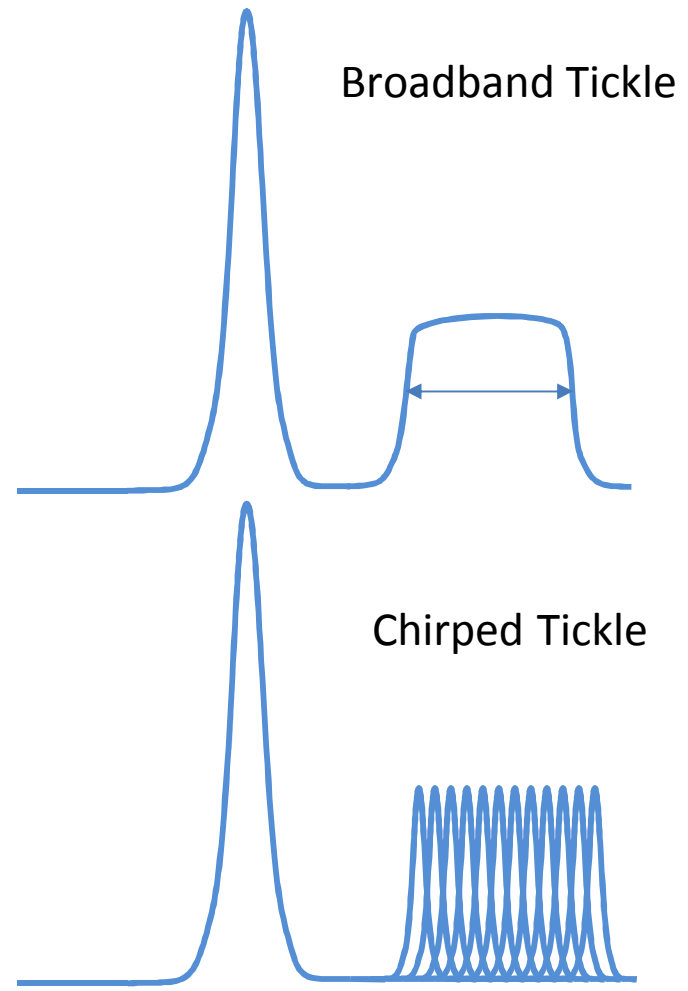
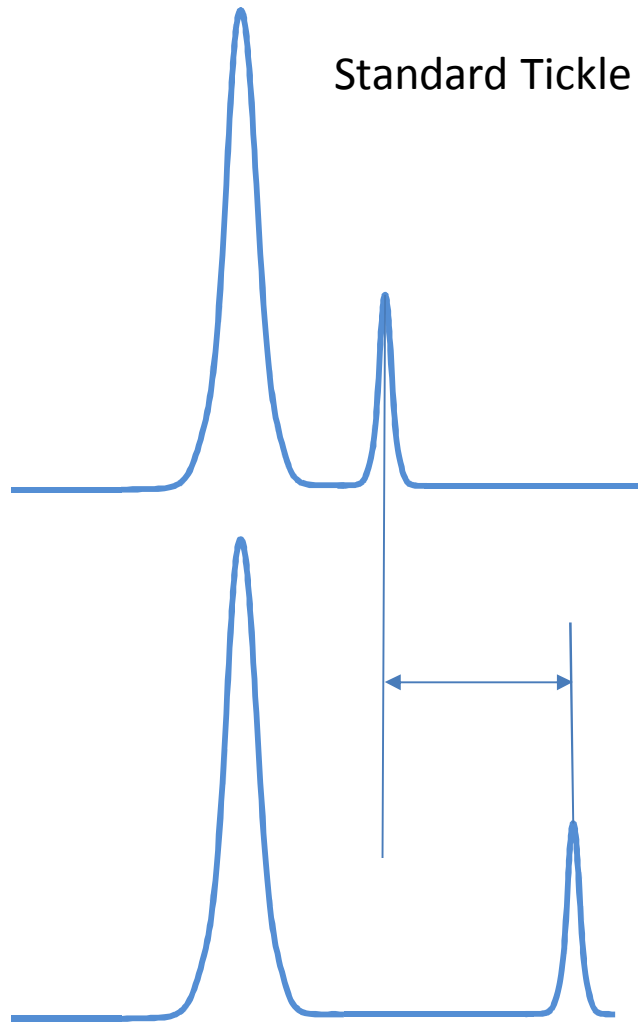
# Compensation Q-section

Compensation field varies slowly along linear quantum section of the trap

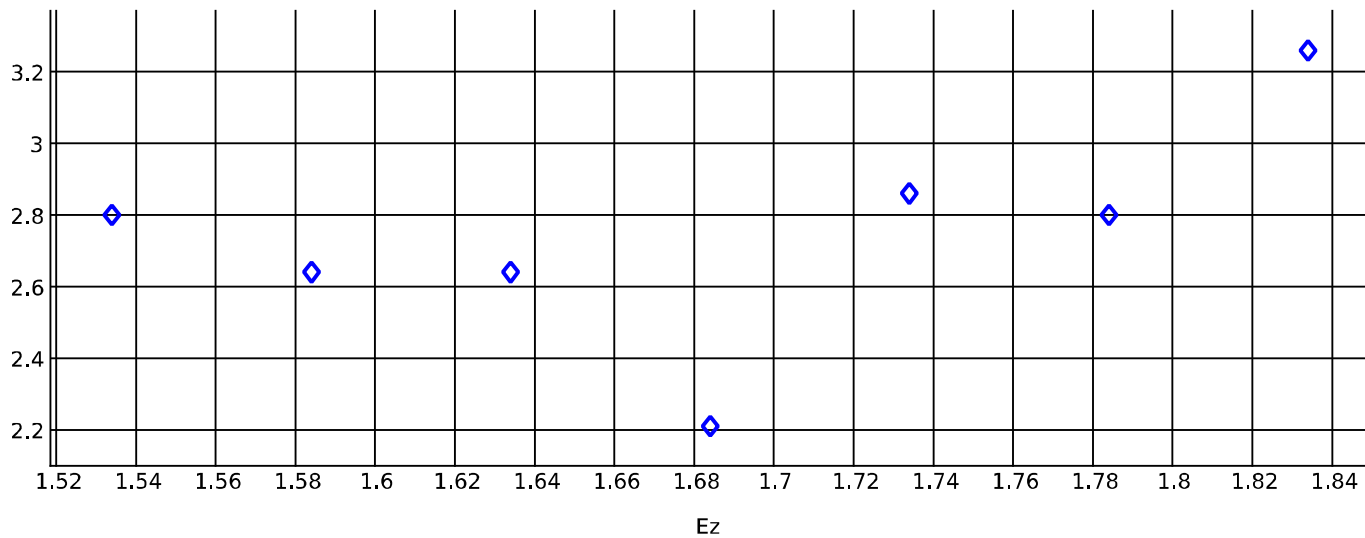
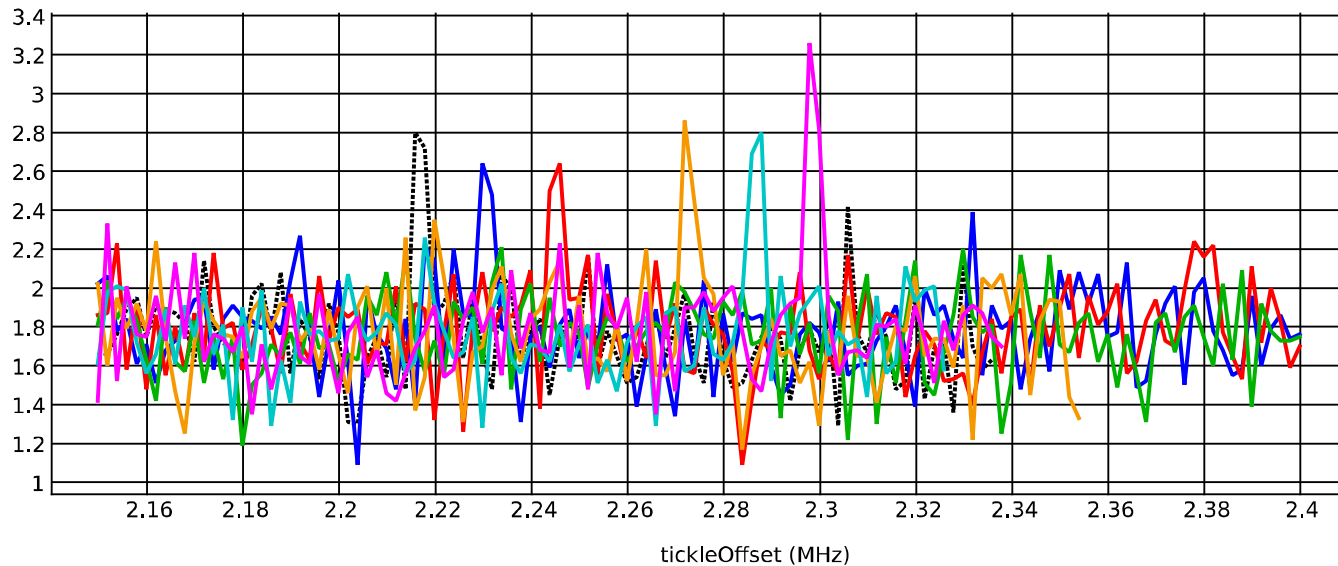




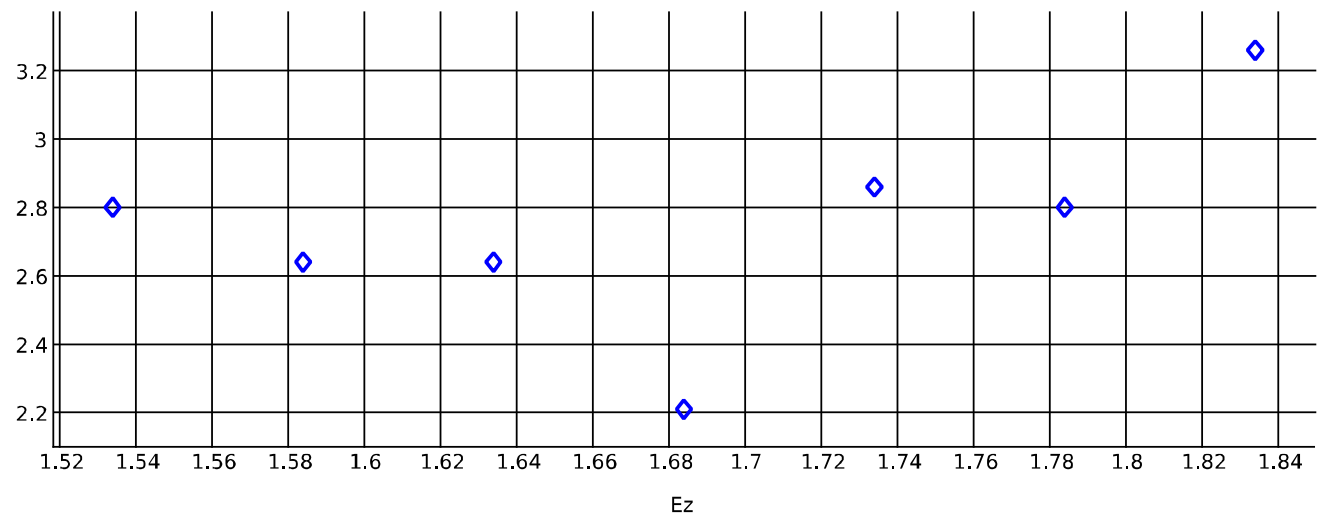
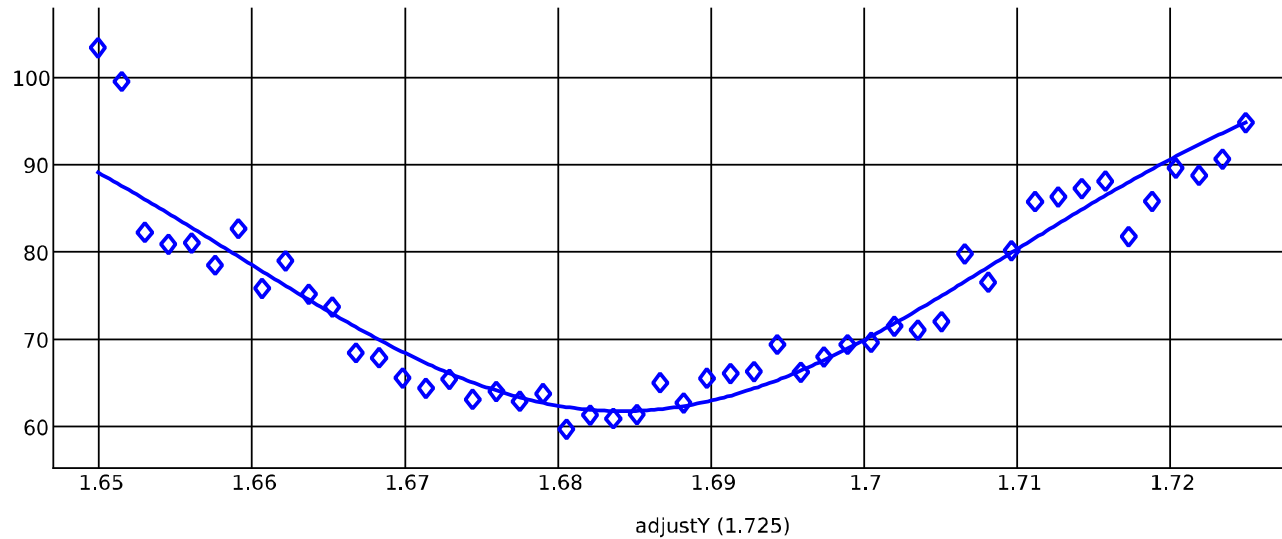
# Vertical Micromotion Compensation



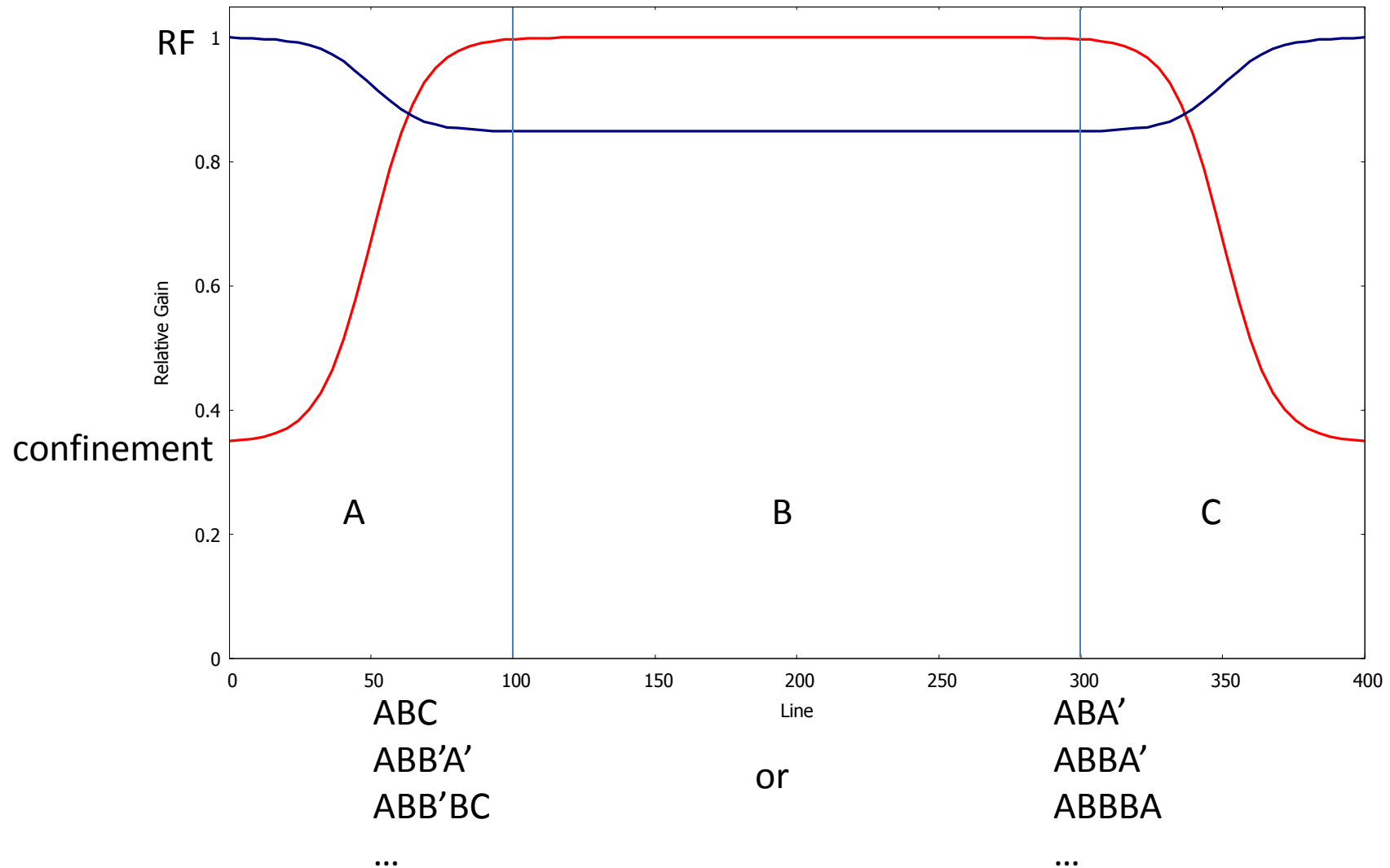
# Standard Tickle Scan



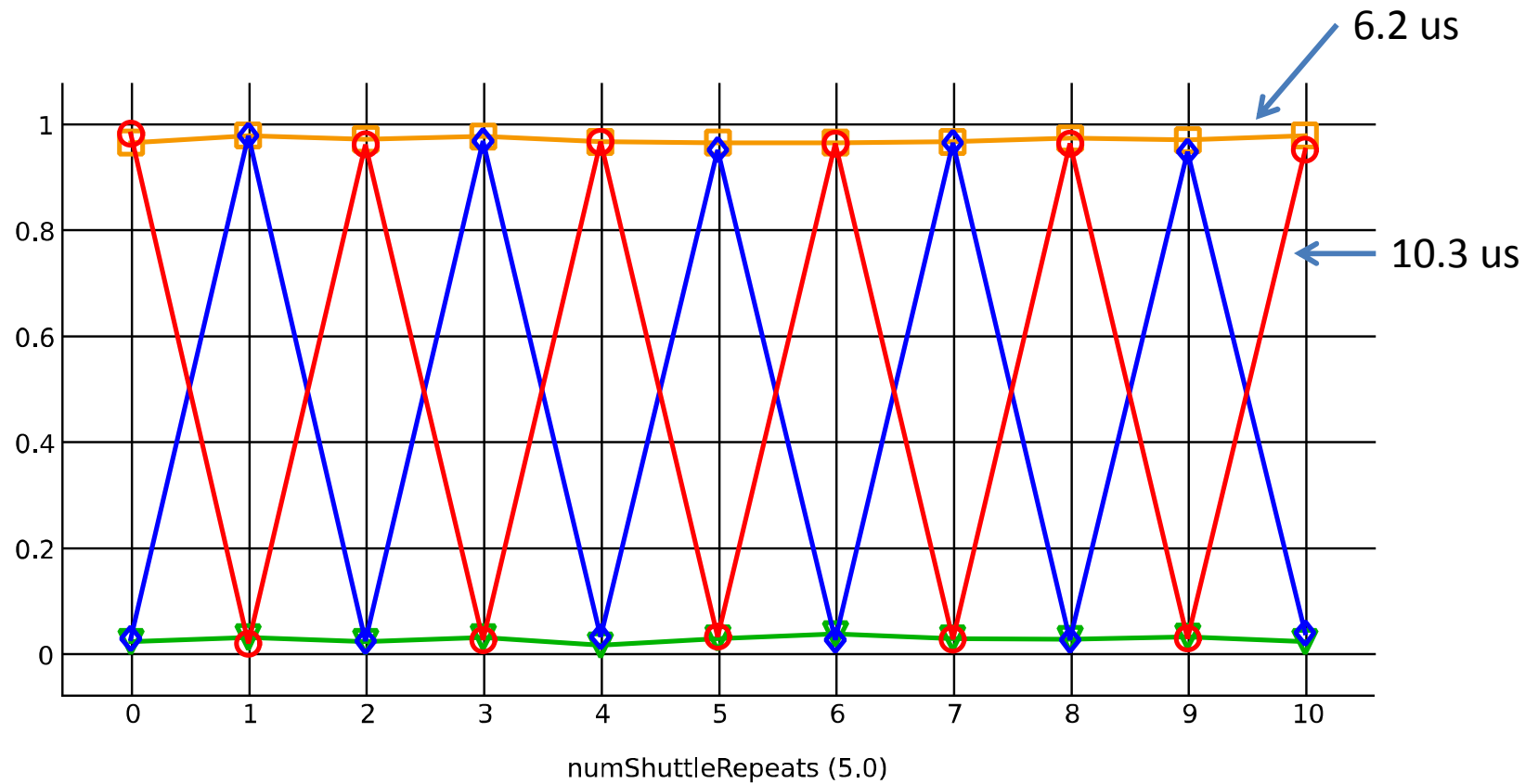
# Chirped vs Standard Tickle



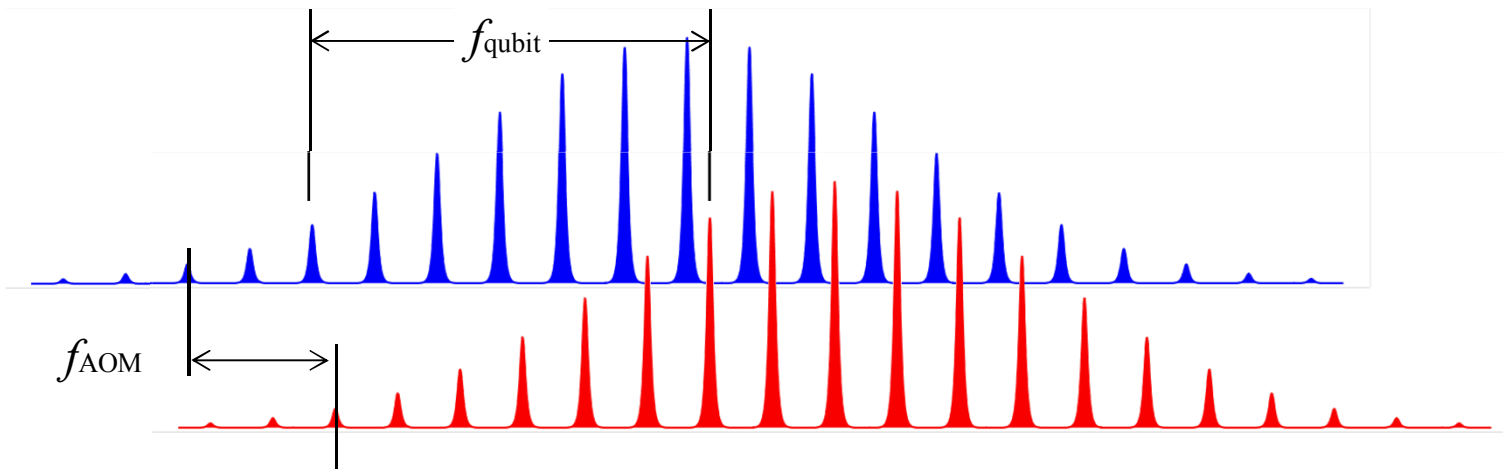
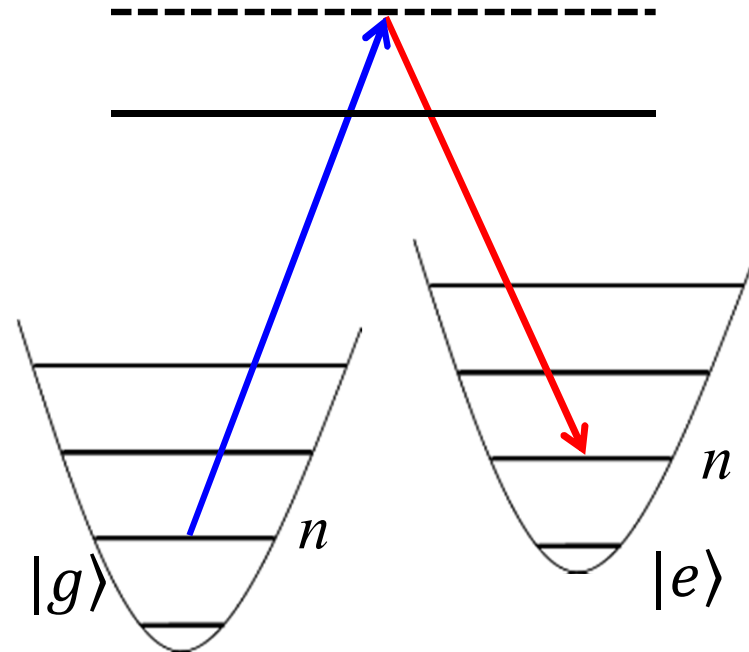
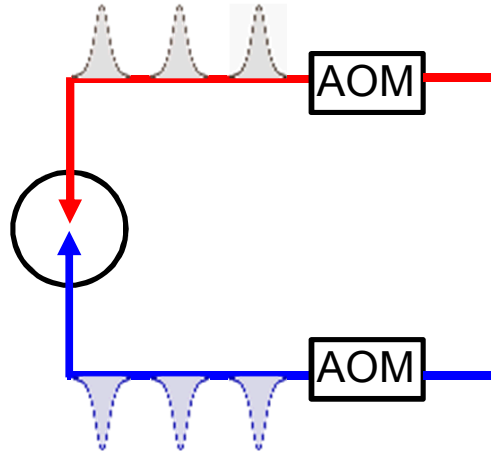
# Rotation Solution with RF and axial confinement ramp



# Breakdown of swap

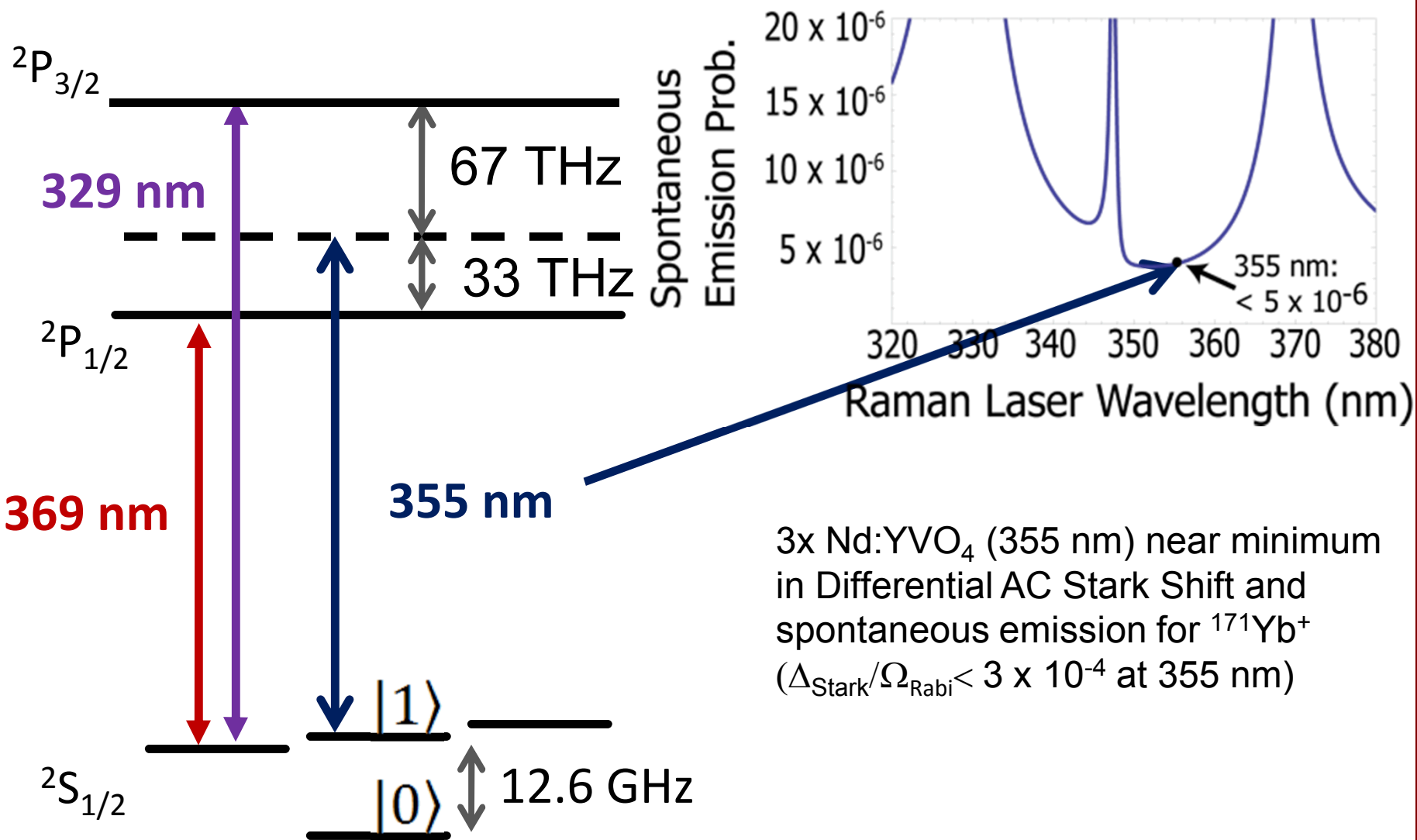


# Pulsed laser Raman transitions



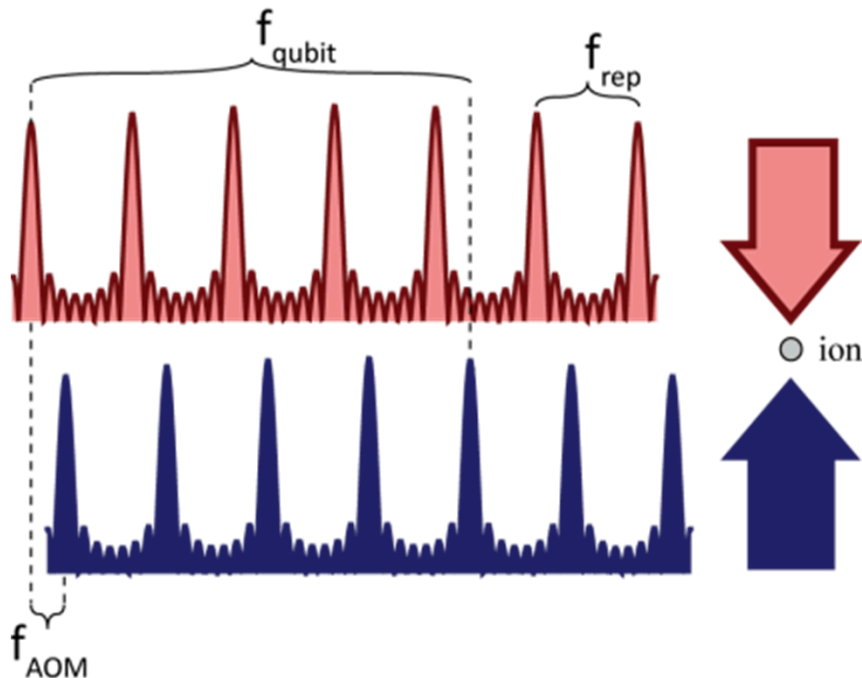


# 355 Raman transitions: $^{171}\text{Yb}^+$



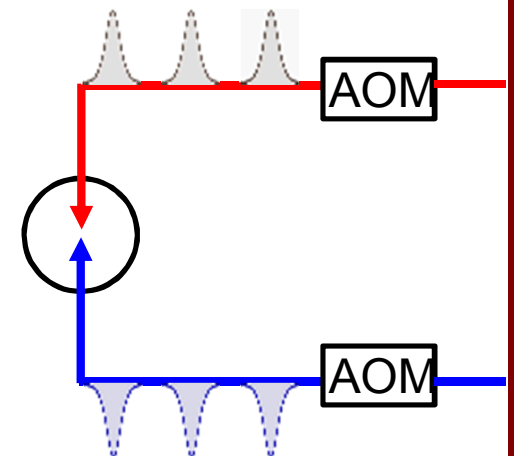
# Pulsed laser Raman transitions

- Couple to ions using 355nm frequency comb
- Beat note created by repetition rate and AOM shift
- Get large splitting for free

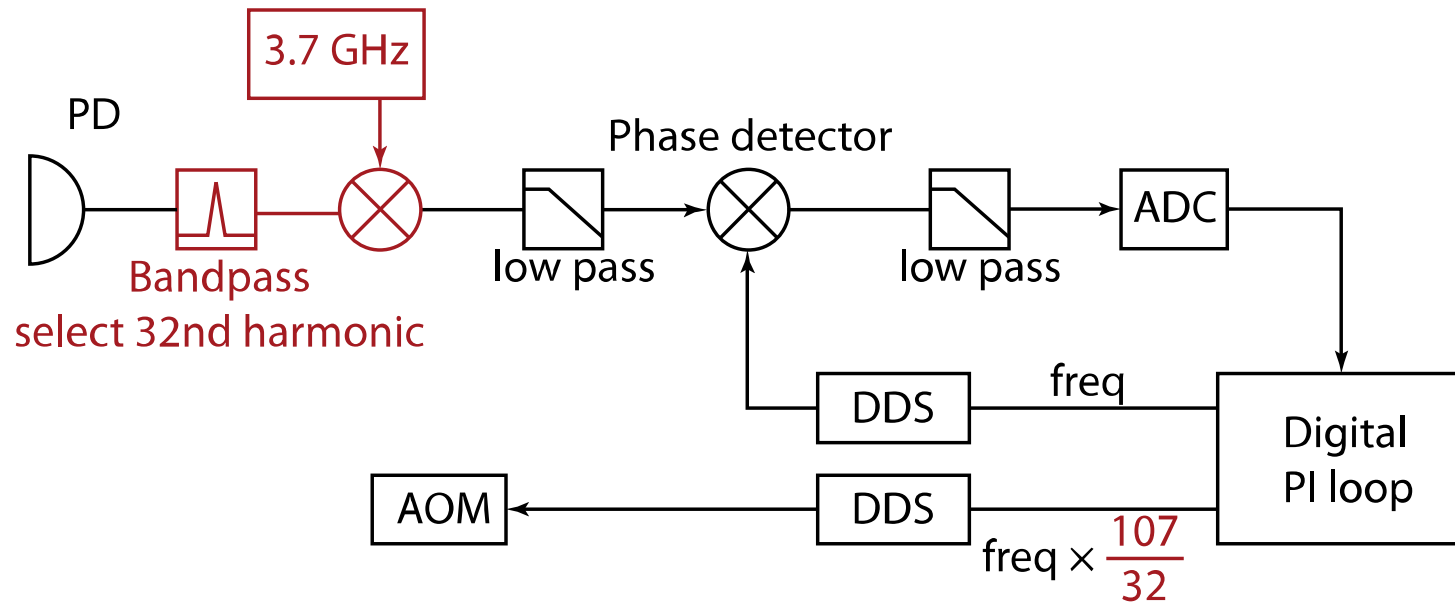


**Requirement:**

$$f_{\text{qubit}} = n f_{\text{rep}} \pm f_{\text{AOM}}$$



# Stabilizing the beatnote frequency



# *GST: Microwave results*

Best results for microwave single qubit gates:

- BB1 dynamically compensated pulse sequences
- Decoupling sequence for identity gate
- Drift control for  $\pi$ -time and qubit frequency

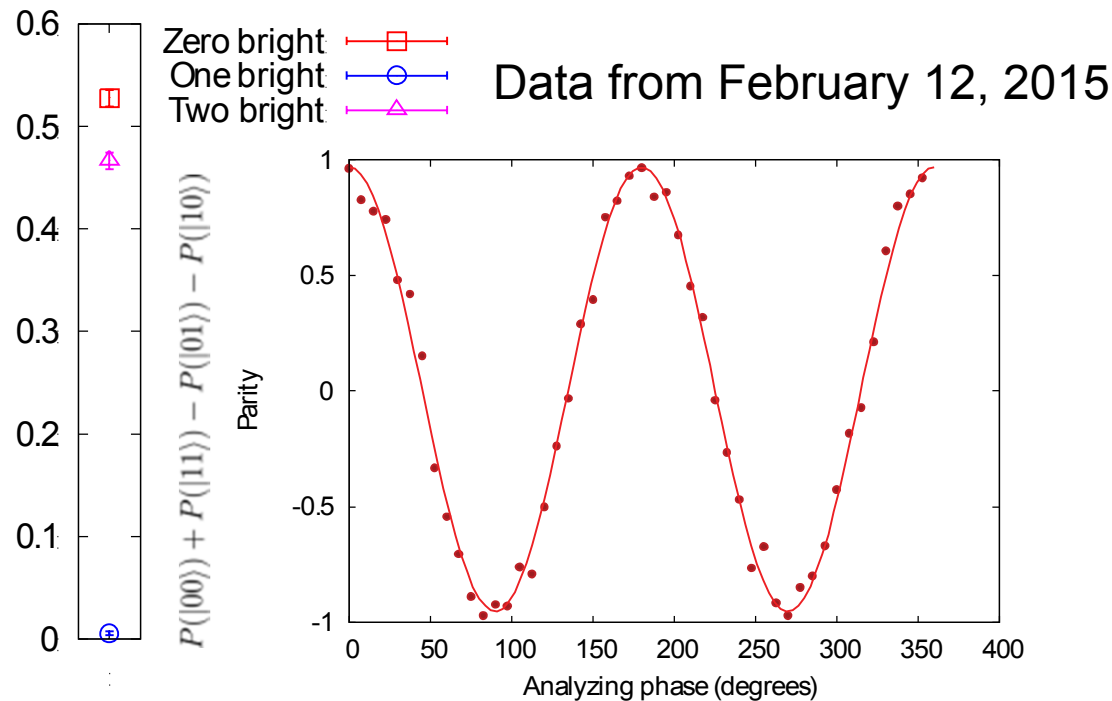
95% confidence intervals

Gate	Process Infidelity	$1/2 \diamond$ -Norm
$G_I$	$6.9(6) \times 10^{-5}$	$7.9(7) \times 10^{-5}$
$G_X$	$6.1(7) \times 10^{-5}$	$7.0(15) \times 10^{-5}$
$G_Y$	$7.2(7) \times 10^{-5}$	$8.1(15) \times 10^{-5}$

All gates are better than the fault tolerance threshold of  $9.7 \times 10^{-5}$   
P. Aliferis and A. W. Cross, Phys. Rev. Lett. 98, 220502 (2007).

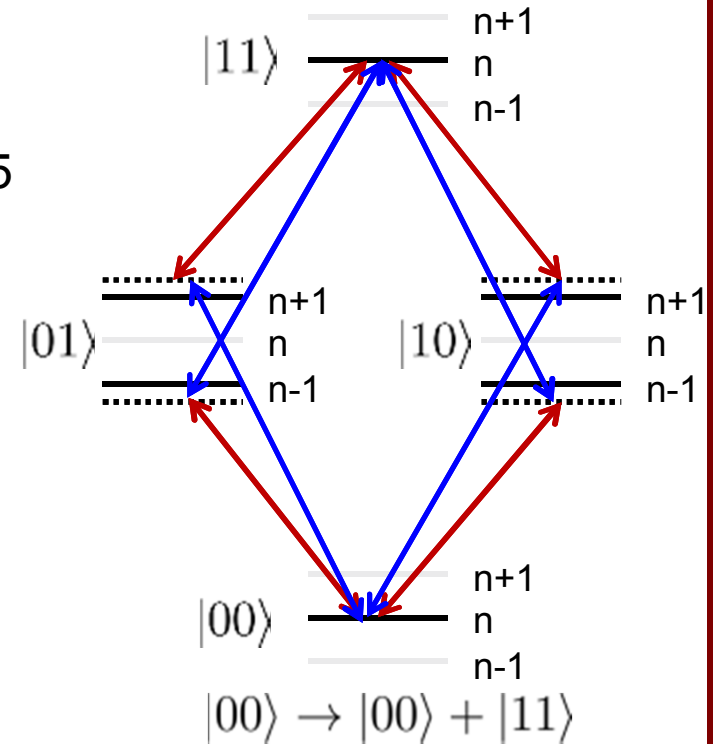
# Two-qubit gate implementation

- Implemented using Walsh compensation pulses
- Optical phase sensitive



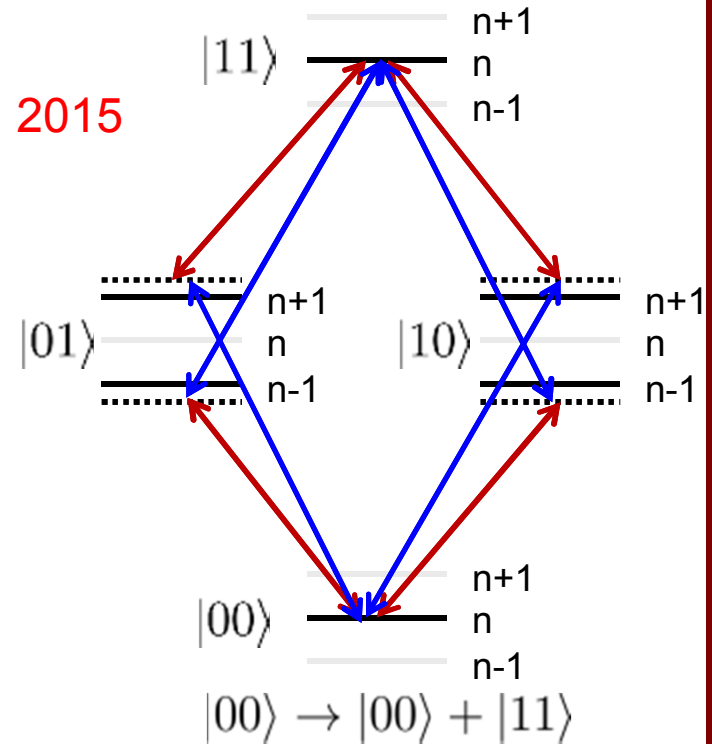
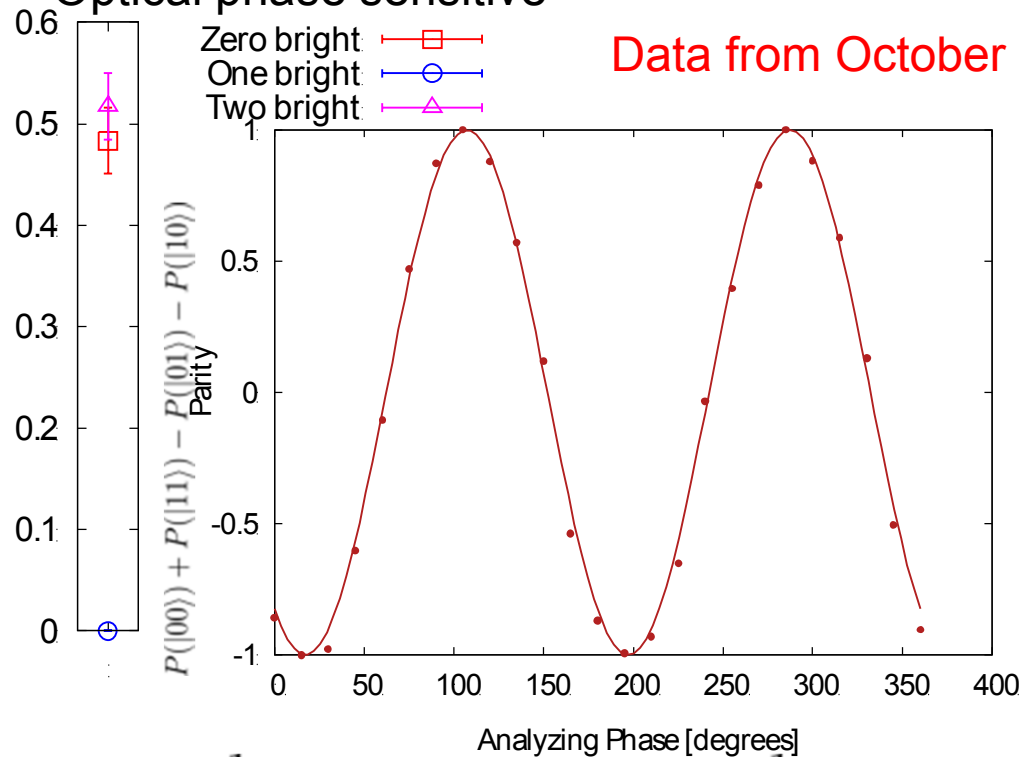
$$\mathcal{F} = \frac{1}{2}(P(|00\rangle) + P(|11\rangle)) + \frac{1}{4}c = 0.977$$

Data from February 12, 2015



# Two-qubit gate implementation

- Implemented using Walsh compensation pulses
- Optical phase sensitive



$$\mathcal{F} = \frac{1}{2}(P(|00\rangle) + P(|11\rangle)) + \frac{1}{4}c = 0.977$$

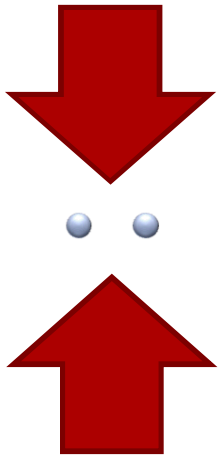
Data from February 12, 2015

$$\mathcal{F} = \frac{1}{2}(P(|00\rangle) + P(|11\rangle)) + \frac{1}{4}c \approx 0.995$$

Data from October 10, 2015



# *Process fidelity of two-qubit gate*



Currently:

- Two ions in single trap well
- No individual addressing
- Ideally all operations are symmetric
- Only symmetric subspace of two-qubit Hilbert space is accessible

Solution:

Perform GST on symmetric subspace  
of two-qubit Hilbert space

Fundamental gates:

$$G_I$$

$$G_{XX} = G_X \otimes G_X$$

$$G_{YY} = G_Y \otimes G_Y$$

$$G_{MS}$$

9 Preparation Fiducials

12 Germs

6 Measurement Fiducials:

# GST

## *debugging of the setup*

GST characterizes the implemented processes and helps identify problems  
 $X_{\pi/2}$  and  $Y_{\pi/2}$  gates implemented using BB1 pulse sequence

4/17: Markovianity violation

- Improve passive stability
- Add drift control of  $\pi$ -times

12/2: Improved X and Y gates, identity is worst

- Decoupled identity using  $X_{\pi} W_{1.25\pi} - X_{\pi} W_{1.25\pi}$
- Switched to HOA-2 trap

2/9: Gates improved, systematic over-rotation detected

- Improve calibration of BB1 pulses
- Drift control of qubit frequency

3/2: X and Y gates are good, identity is still worst

- Implement identity as  $X_{\pi} Y_{\pi} X_{\pi} Y_{\pi}$

3/30: Process fidelity of all gates  $\leq 6 \times 10^{-5}$

